

Integrated Photonics on Silicon for the Visible Spectrum

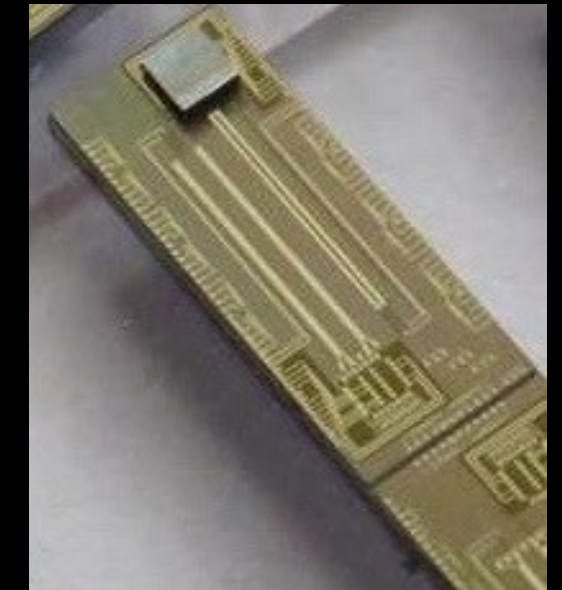
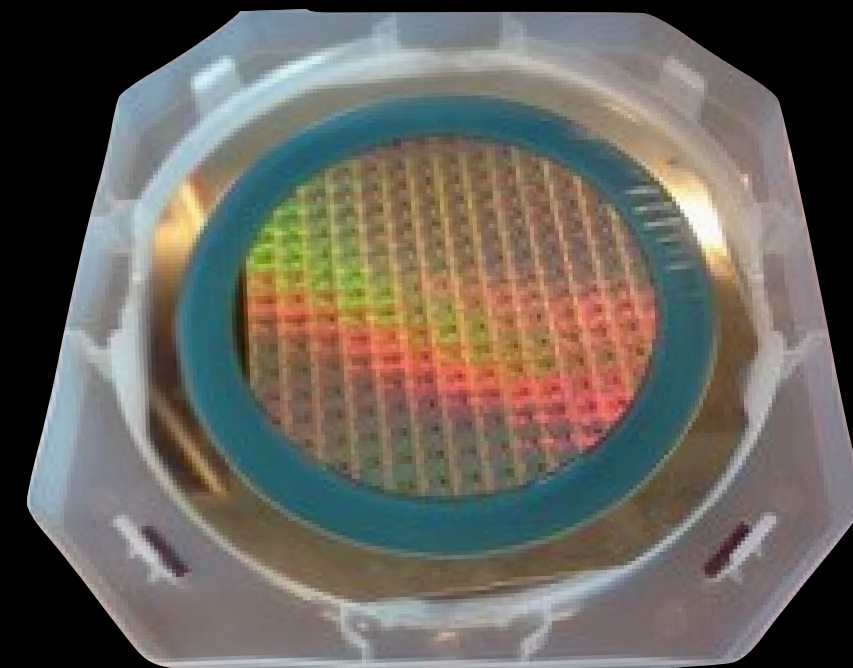
Joyce Poon

Max Planck Institute for Microstructure Physics
University of Toronto

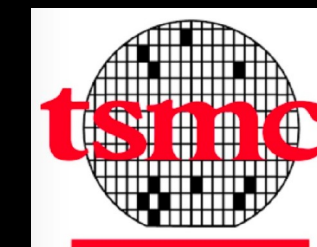


Foundry silicon photonics

Manufacture photonic chips in microelectronics infrastructure
⇒ scalability, \$B industry



200 or 300 mm dia.



Foundry silicon photonics: the opportunity

Large wafers

⇒ Mass-manufacturing, reduce cost

High density integration

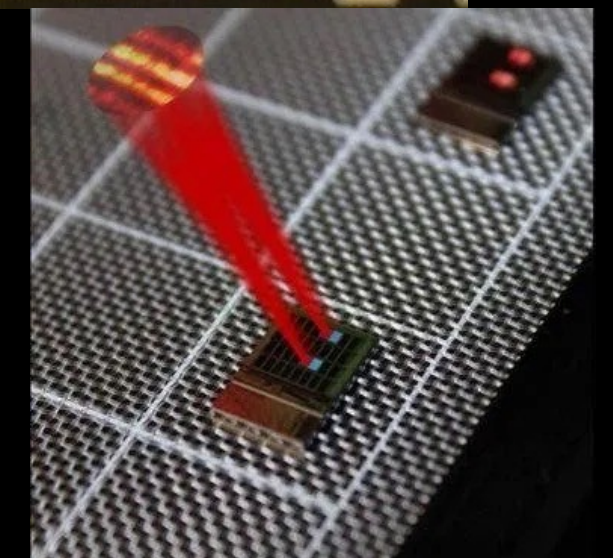
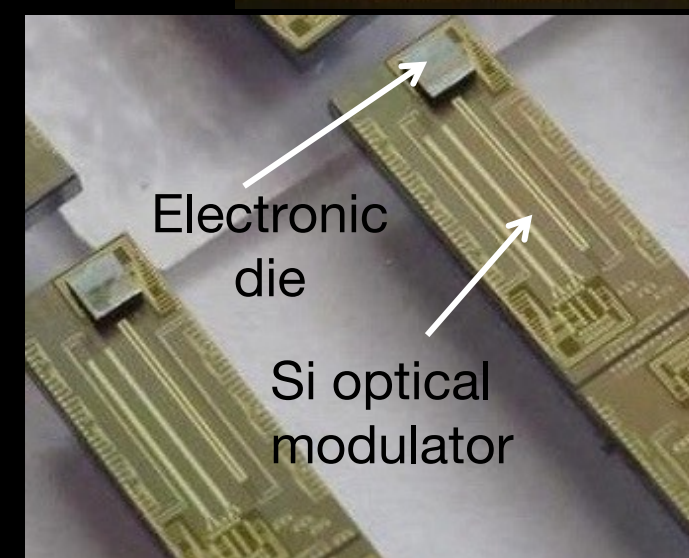
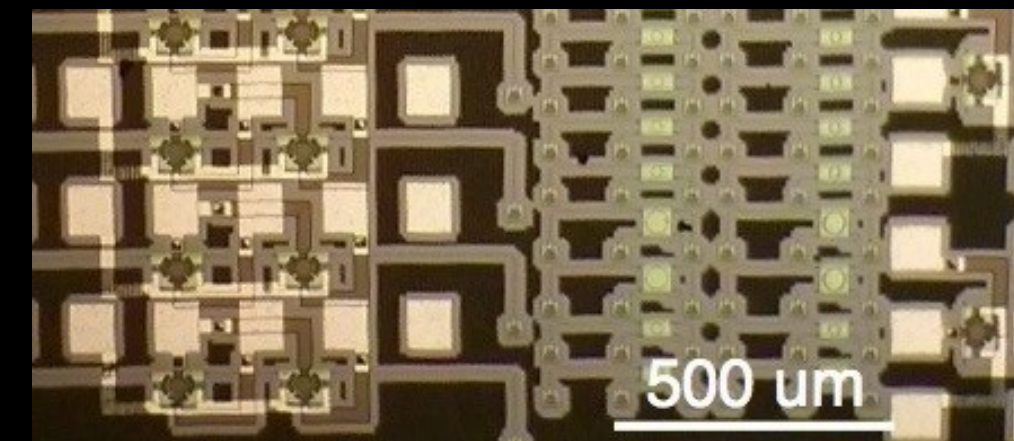
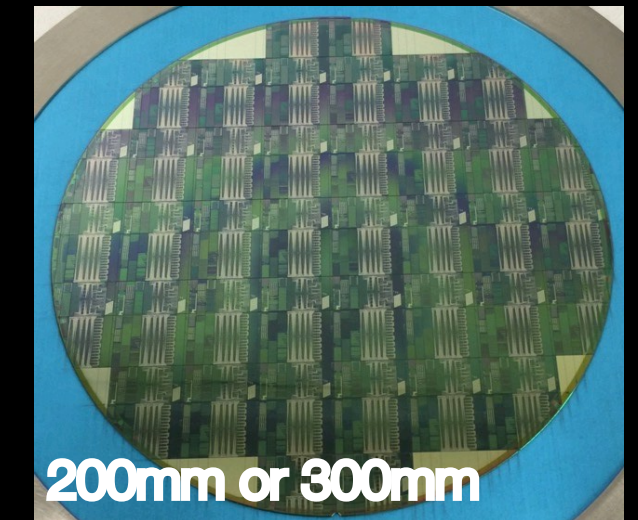
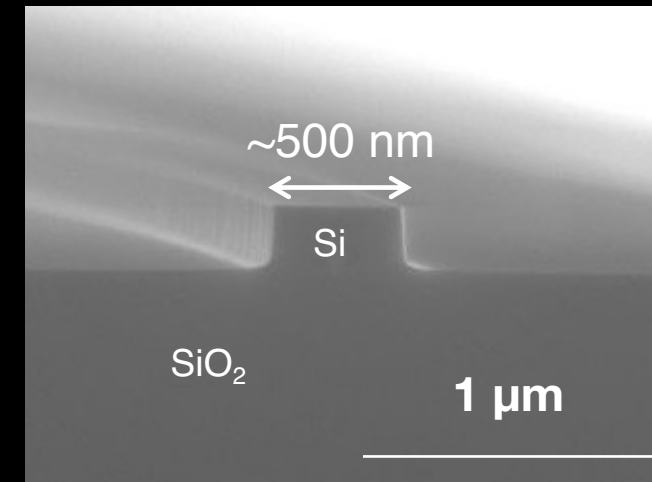
⇒ Sophisticated photonic circuits

2D and 3D integration

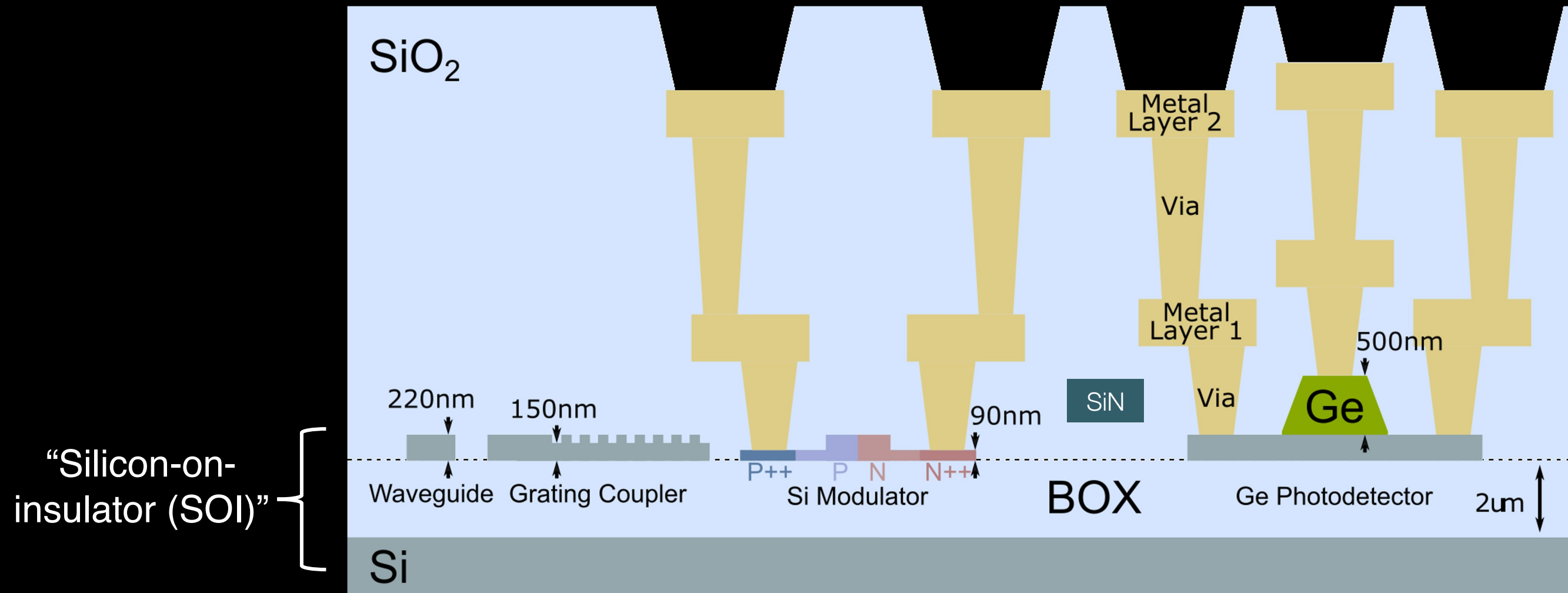
⇒ Combine photonics with electronics, other technologies

Photonics for a broader range of applications

⇒ Go beyond telecom

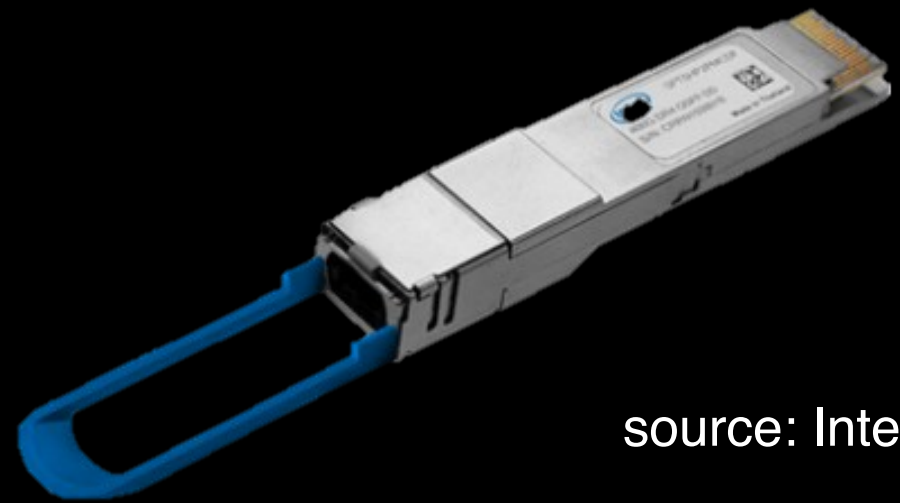


Cross-section of a typical Si photonic platform



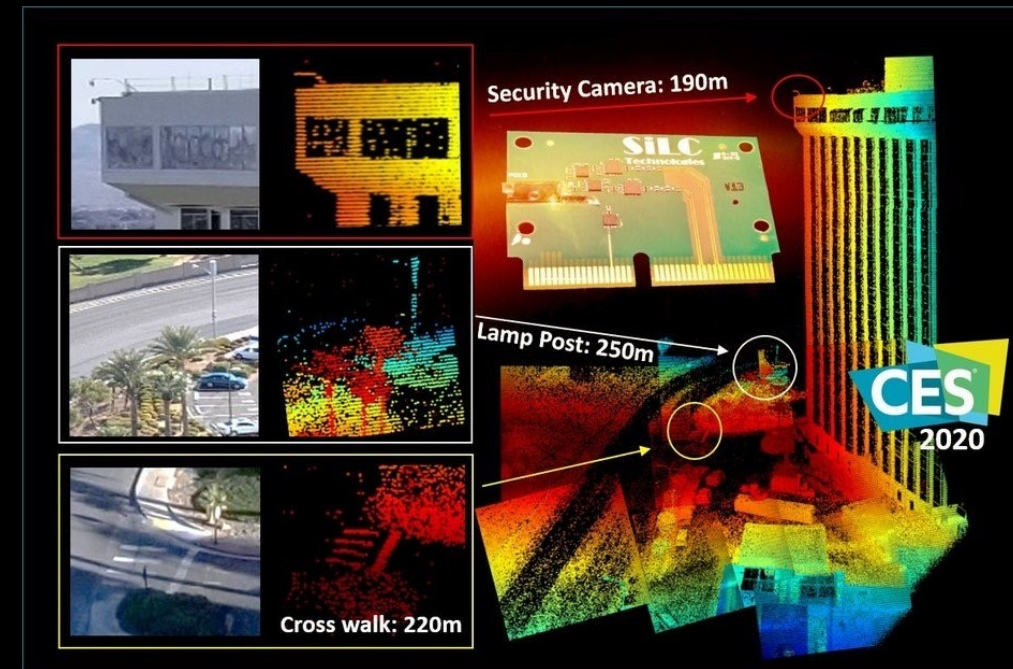
- Si waveguide (2-3 etch depths)
- Silicon nitride waveguide
- 2-3 routing metal layers
- Silicon modulators (P, N implants)
- Germanium photodetectors
- Telecom applications

Commercialization ongoing



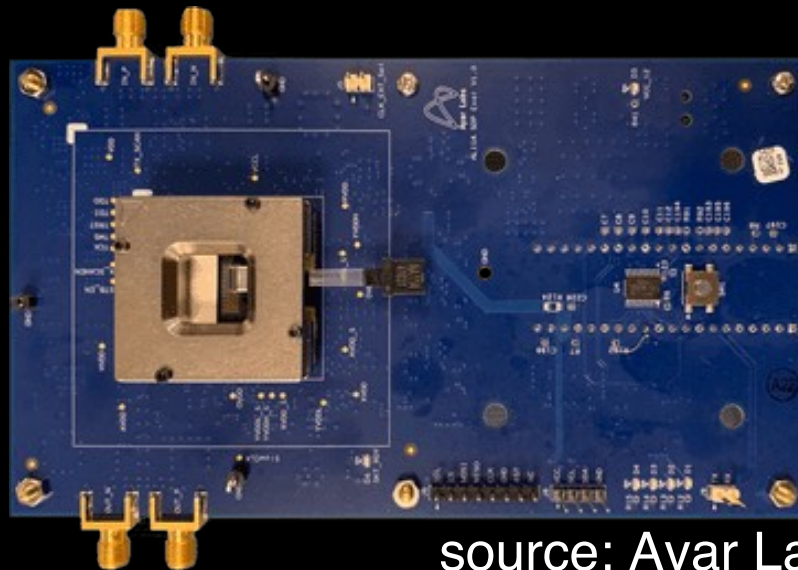
source: Intel

Transceivers



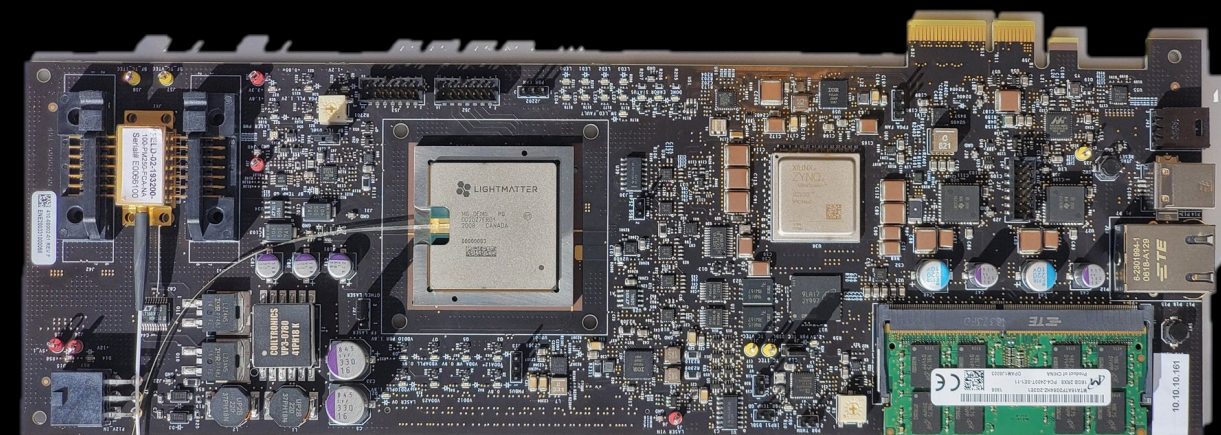
LiDAR

source: SiLC



source: Ayar Labs

Optical I/O

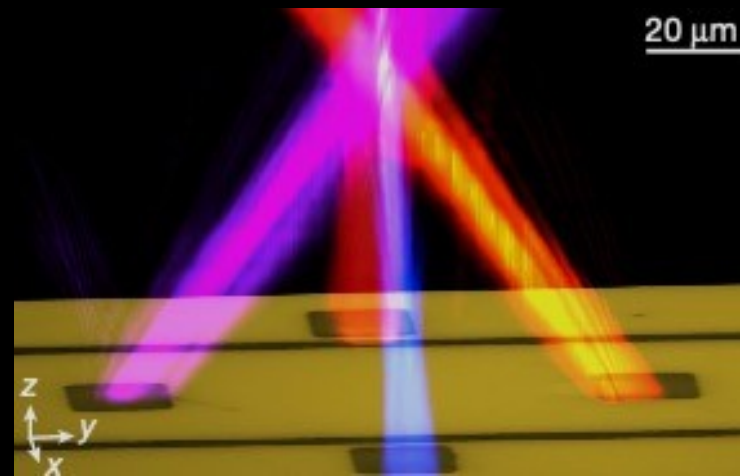


source: LightMatter

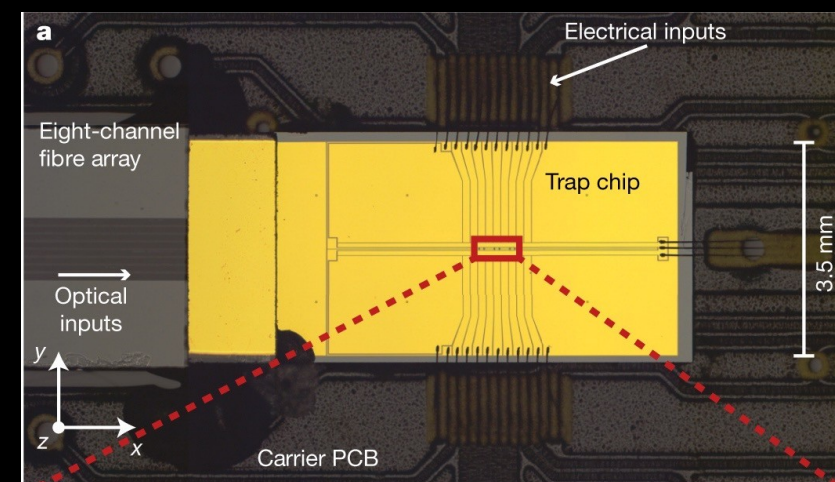
Special Purpose Compute Engines

Si photonics for the visible spectrum? Some applications

Quantum Science and Computing (ion traps and cold atoms)

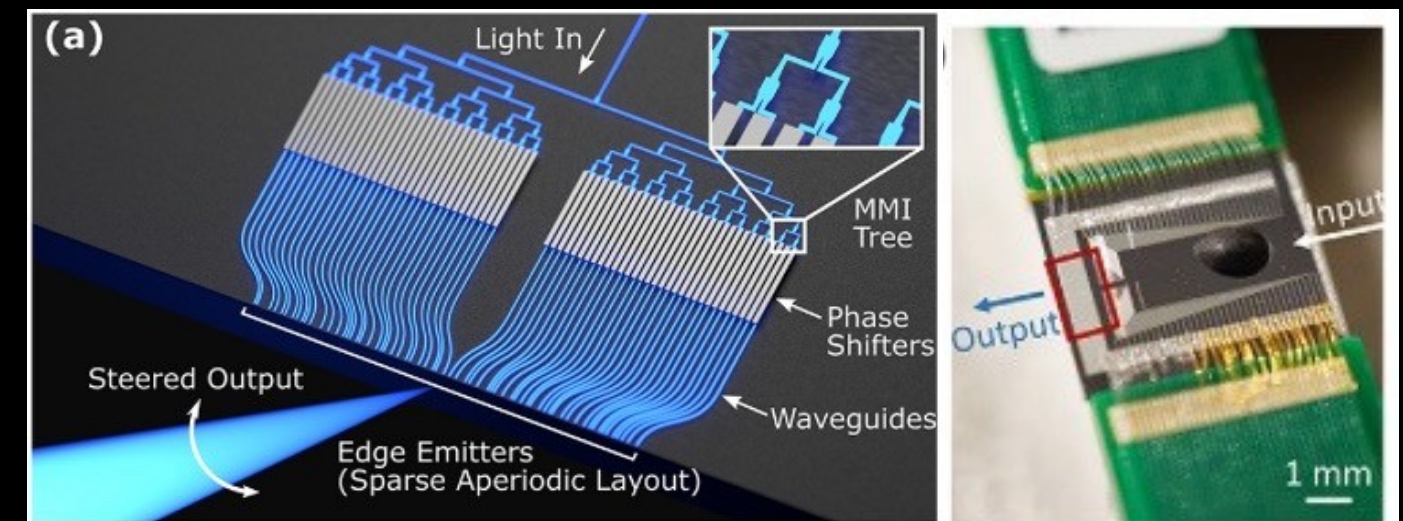


R. J. Niffenegger et al., Nature, 2020.



K. K. Mehta et al., Nature, 2020.

Beam-Scanners



Shin et al., Optics Letters, 2020.

Spectroscopy and Fluorescence Sensing



Benefits of silicon photonics \neq Silicon waveguides!

Elements used in the semiconductor industry

■ *Used in/before 1980s*
■ *Added or explored in 2000s*
■ *Added in 1990s*
■ *Added or explored in 2010s*

IA													IIIA	IVA	VA	VIA	VIIA	VIIIA																												
H													B	C	N	O	F	He																												
Li	Be												Al	Si	P	S	Cl	Ar																												
Na	Mg	IIIB	IVB	VB	VIB	VIIIB	VIIIIB					IIB																																		
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr																													
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe																													
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<table border="1" style="width: 100%; text-align: center;"> <tr> <td>Ce</td><td>Pr</td><td>Nd</td><td>Pm</td><td>Sm</td><td>Eu</td><td>Gd</td><td>Tb</td><td>Dy</td><td>Ho</td><td>Er</td><td>Tm</td><td>Yb</td><td>Lu</td> </tr> <tr> <td>Th</td><td>Pa</td><td>U</td><td>Np</td><td>Pu</td><td>Am</td><td>Cm</td><td>Bk</td><td>Cf</td><td>Es</td><td>Fm</td><td>Md</td><td>No</td><td>Lr</td> </tr> </table>																			Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr
Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu																																	
Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr																																	



SiN or Al₂O₃ as waveguides

Selected progress on 200mm or 300mm Si

Material	Foundry	Reported Wavelength	Waveguide Loss	Reference
SiN (PECVD)	IMEC → Pix4Life BioPIX	532-900nm	< 1dB/cm @532nm	A. Z. Subramanian et al., IEEE Photonics Journal, 2013.
SiN	Witzens Group, CMOS Pilot Line	660 nm	< 0.5 dB/cm	S. Romero-García et al., Opt. Express, 2013.
SiN	AIM Photonics	635 nm	?	C, V. Poulton, et al. Opt. Lett. 42, 21-24, 2017.
SiN (LPCVD)	Ligentec	?	0.1 dB/cm?	Press releases
SiN (LPCVD)	LioniX	405-640 nm	0.3-0.4dB/cm @405nm	Mashayekh et al., Opt. Express. 29, 8635, 2021.
Al ₂ O ₃	MIT Lincoln Labs	371-1092 nm	2.6 dB/cm @371nm 0.6 dB/cm @458nm	C. Sorace-Agaskar, et al., Proc. SPIE, 2018.
Al ₂ O ₃	Ram Group, MIT with MIT Lincoln Labs	371-458 nm	3dB/cm @371nm ~1dB/cm @ 458nm	G. N. West et al., APL Photonics, 2018.

Our approach: SiN on 200mm Si, 193nm DUV



- with Advanced MicroFoundry (Singapore)
- Dr. Xianshu Luo
- Dr. Patrick Lo



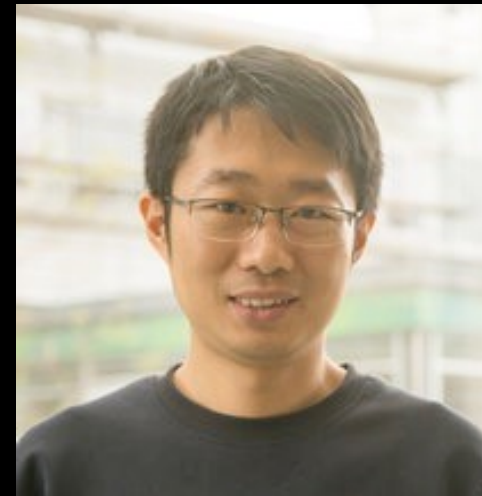
Acknowledgment: Visible Photonics Team



Wesley Sacher



Zheng Yong



Yiding Lin



Saeed Azadeh



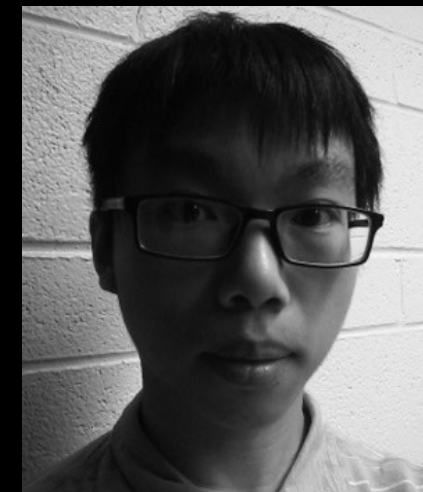
Hong Chen



Alperen Gövdeli



Youngho Jung

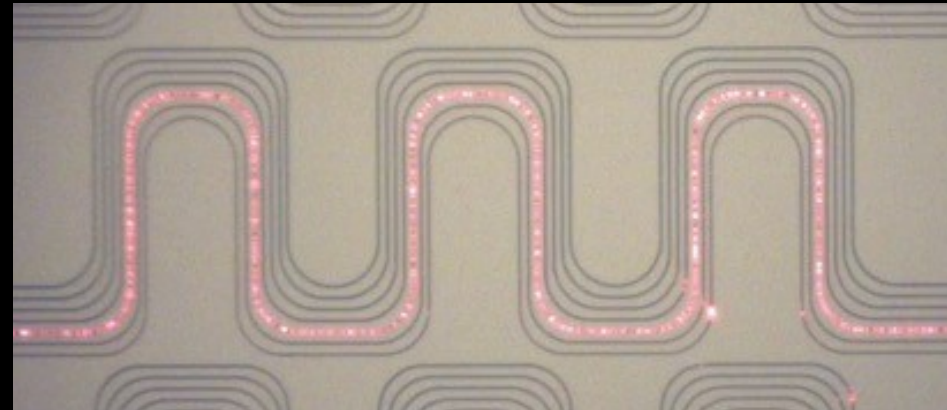
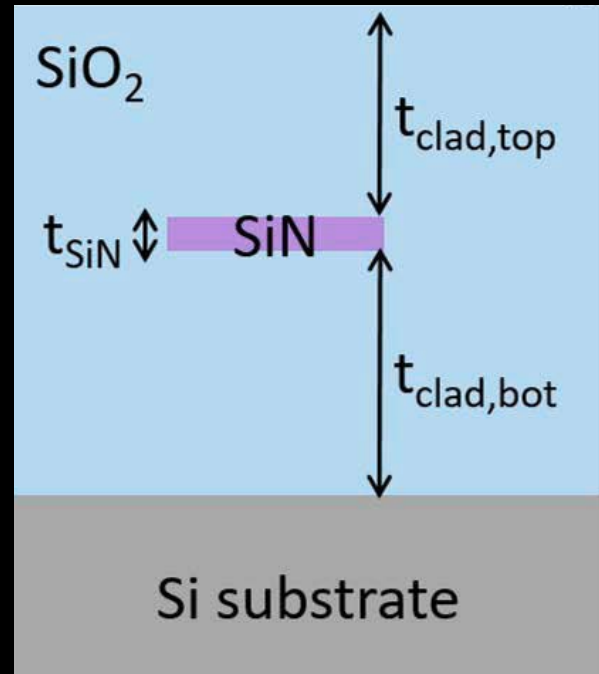


Jason Mak

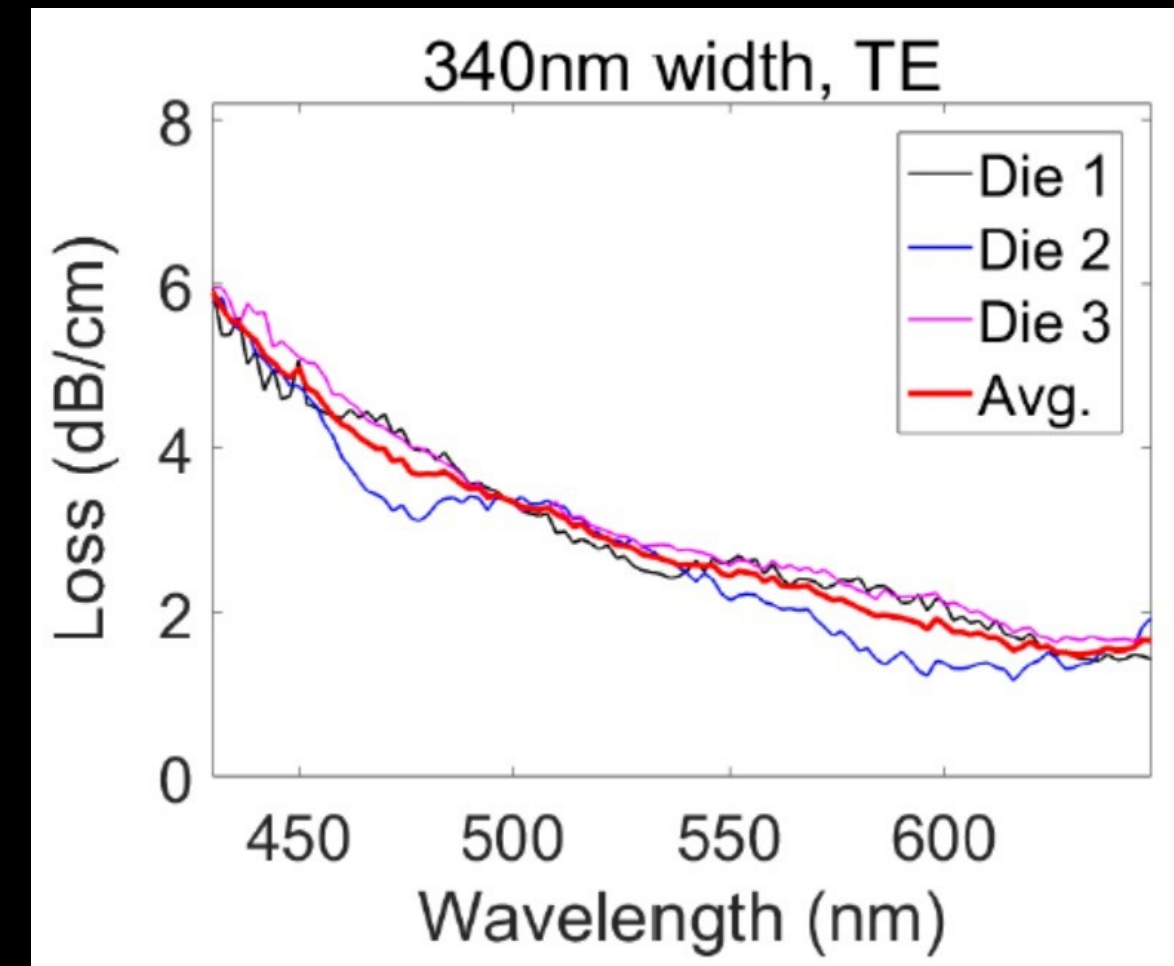
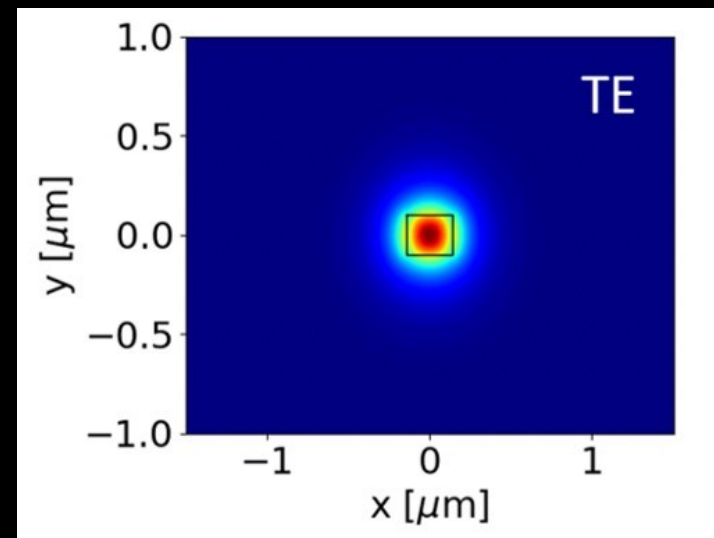
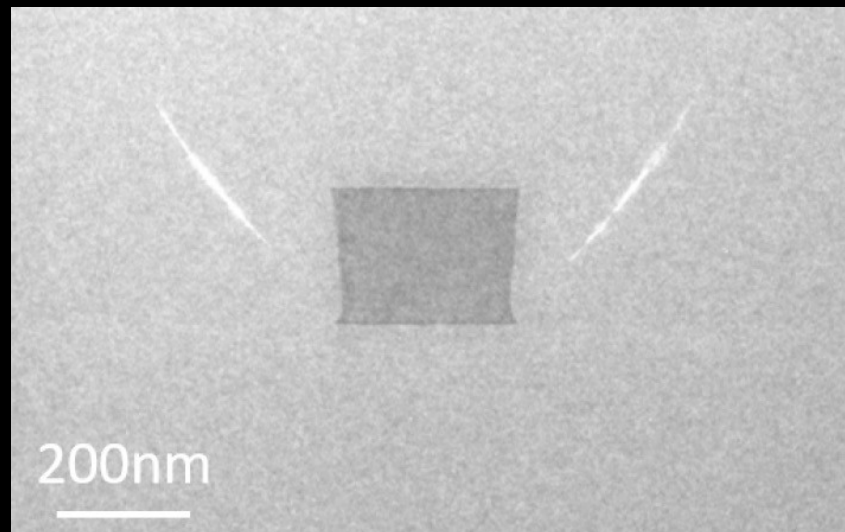


Andrei Stalmashonak

Single-mode, high confinement waveguides

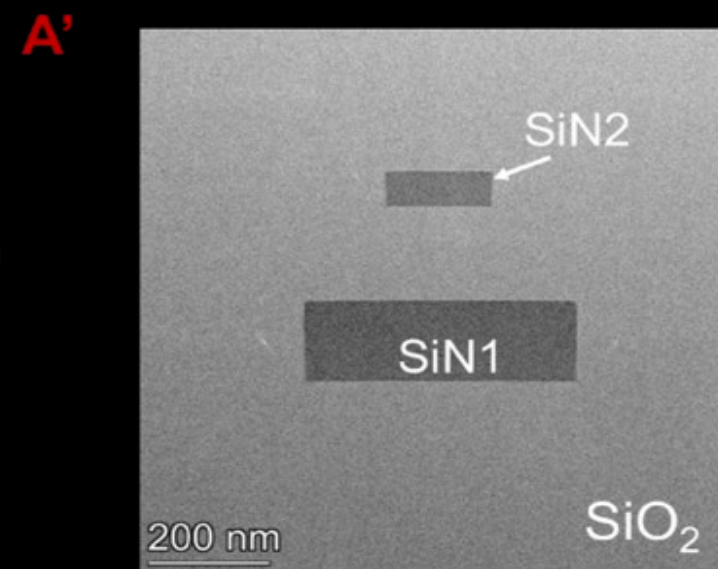
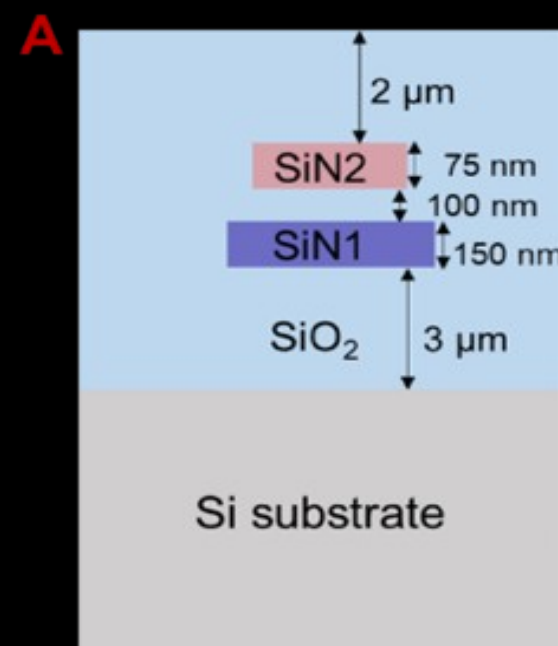
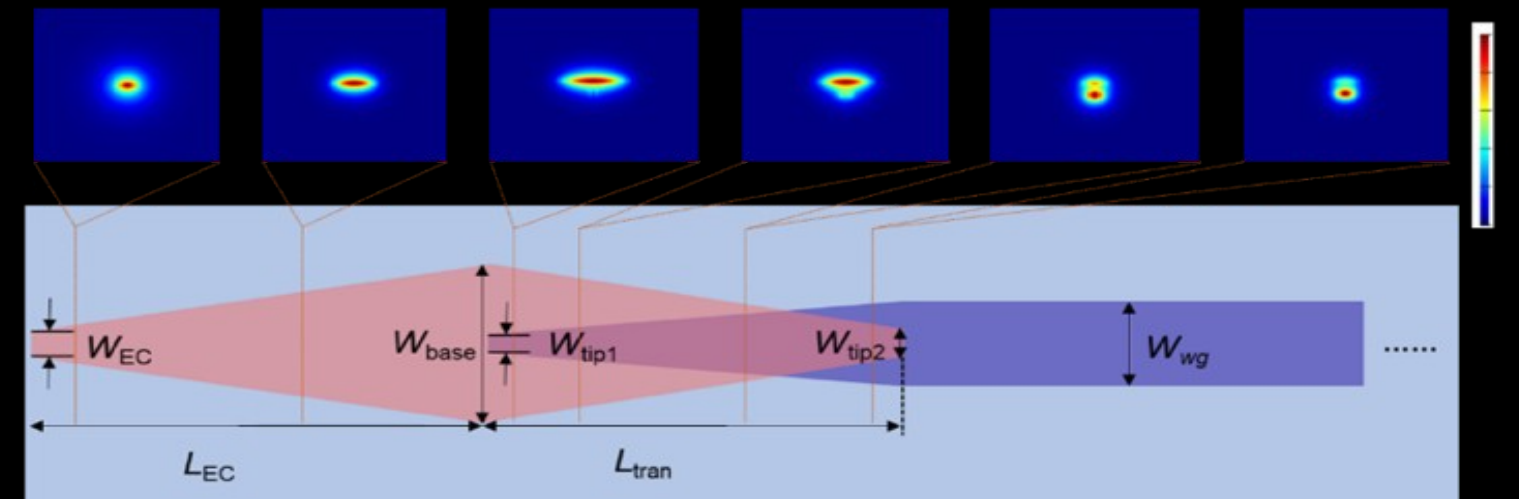
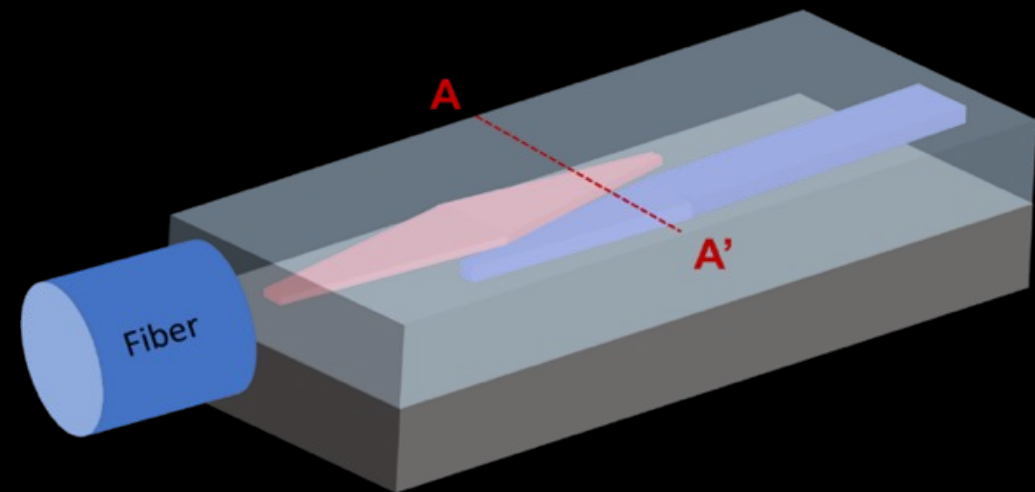


Single-mode waveguide loss
PECVD SiN, 135nm thickness

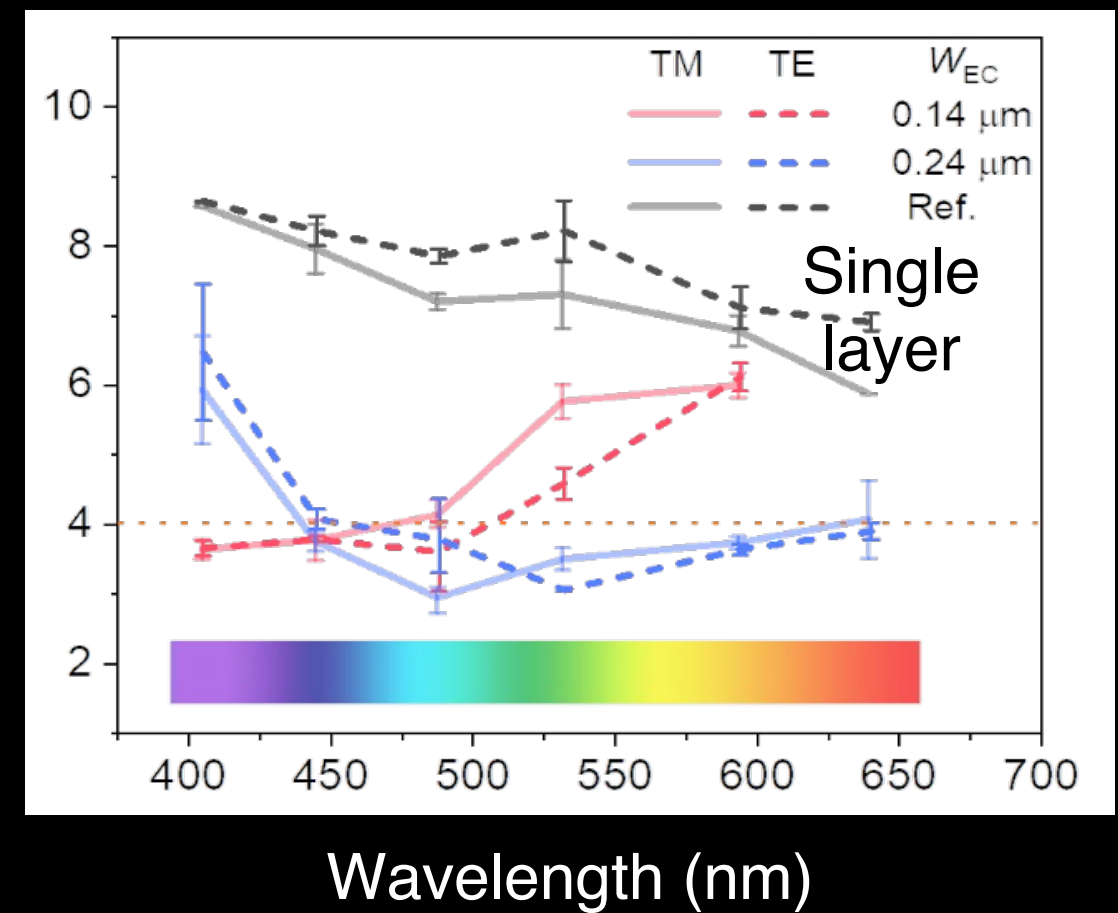


LPCVD SiN similar to PECVD

Bilayer edge couplers

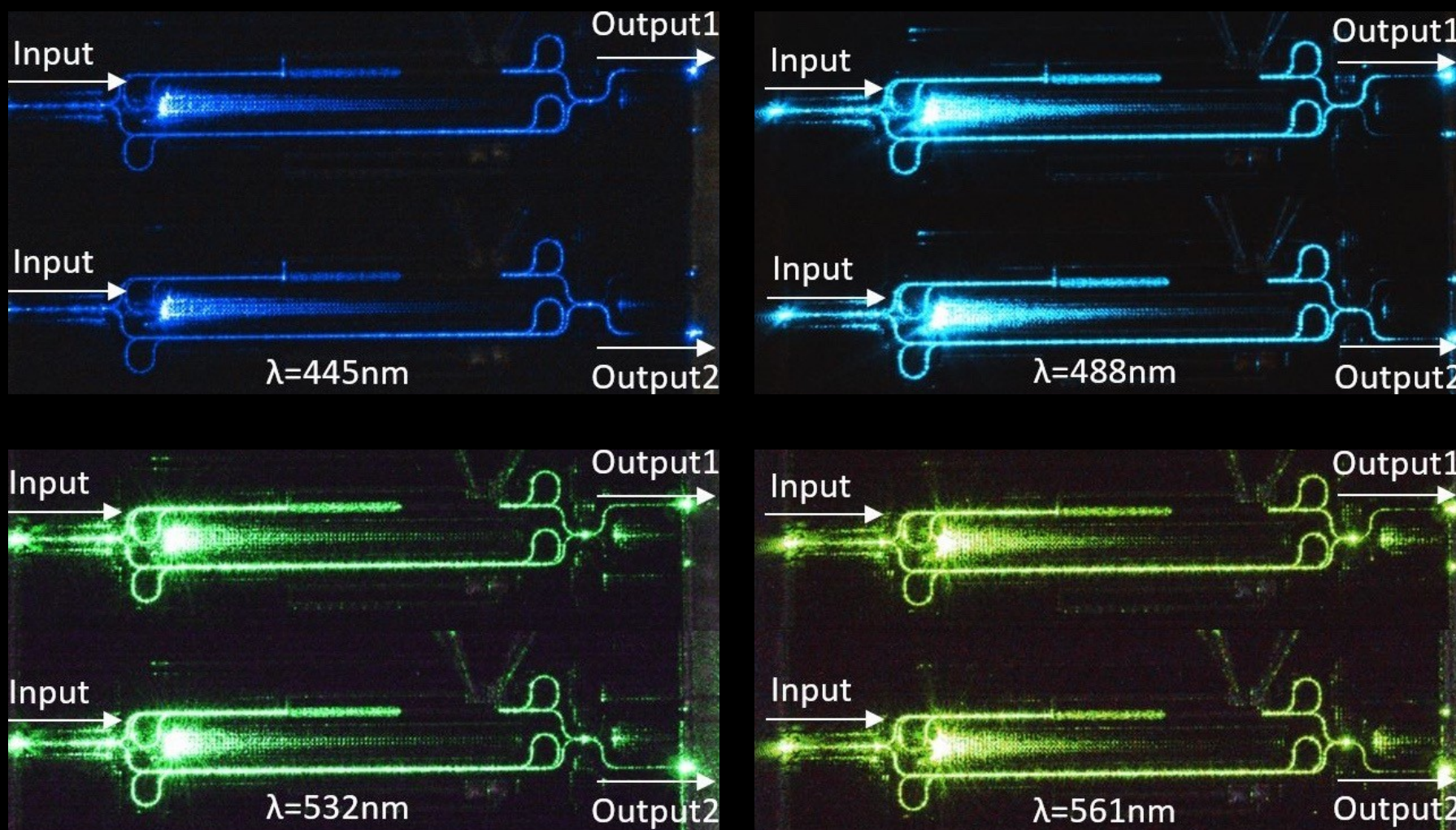


Coupling Loss (dB/facet)

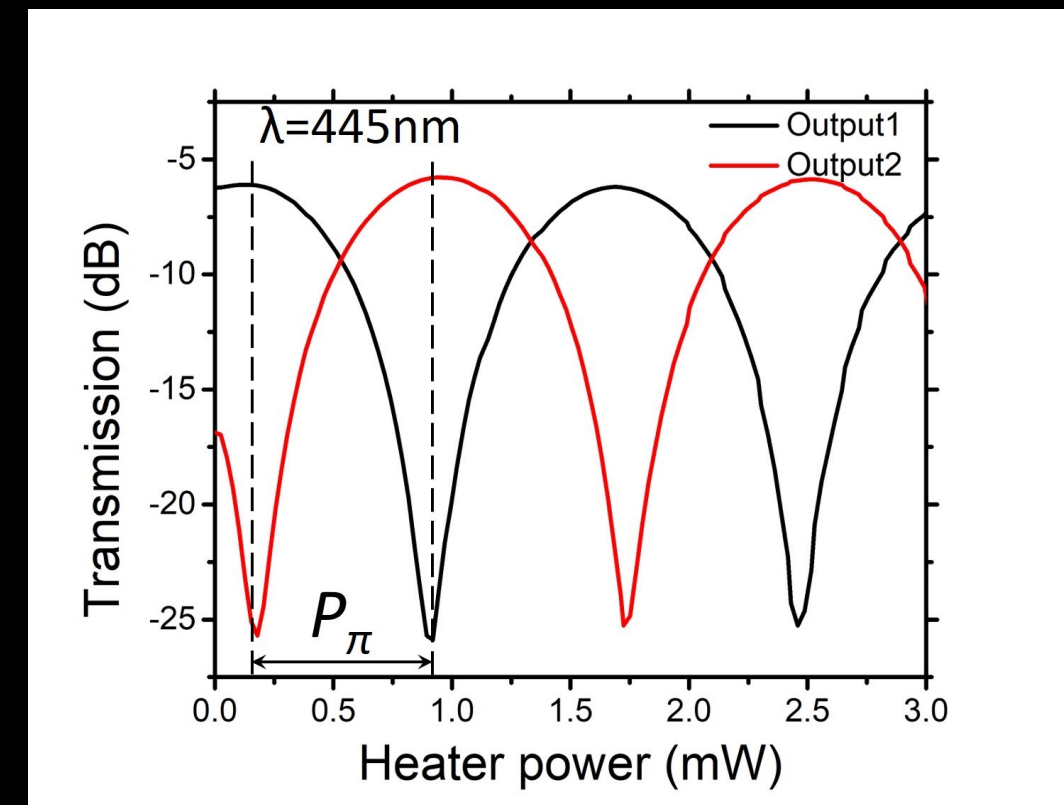


Lin et al., CLEO 2021
Manuscript submitted.

Thermo-optic phase-shifters



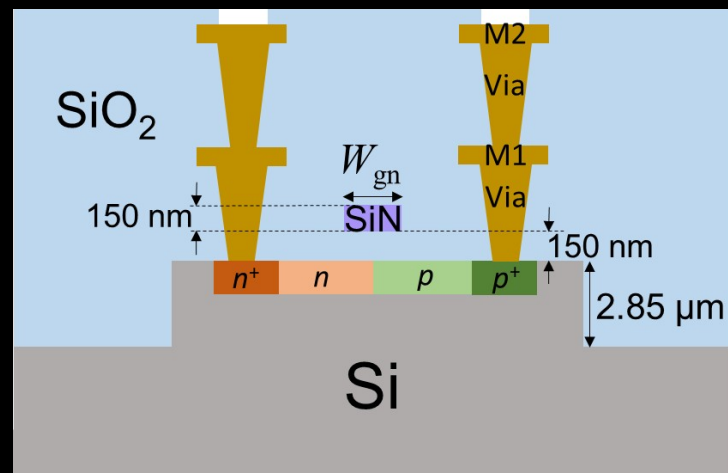
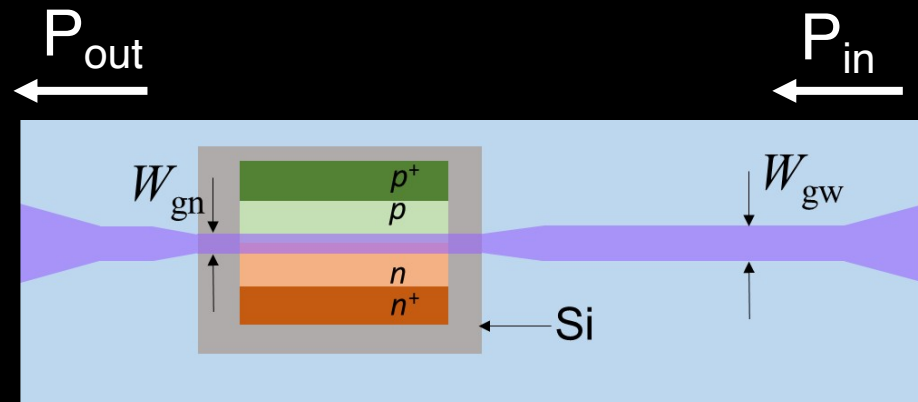
$P_{\pi} \sim 0.8 \text{ mW @ } 445\text{nm}$



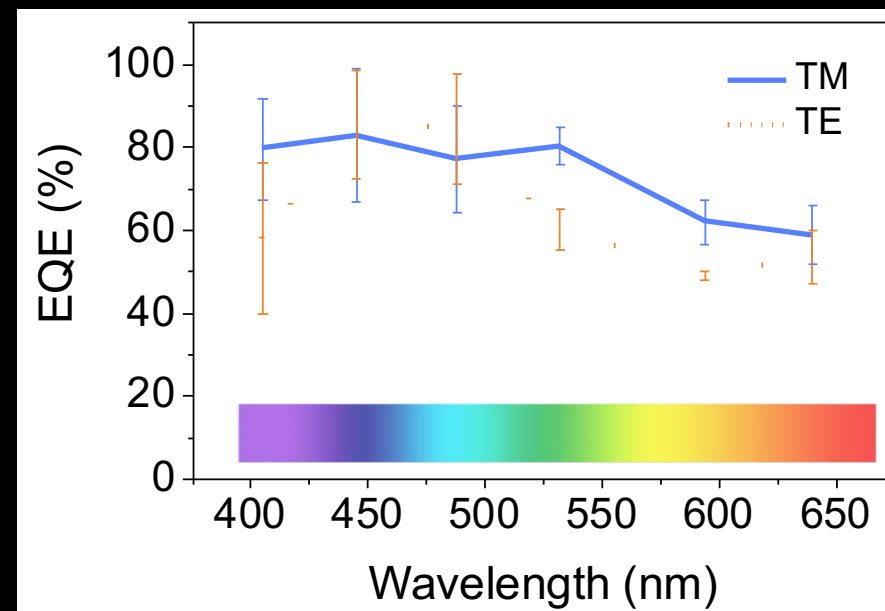
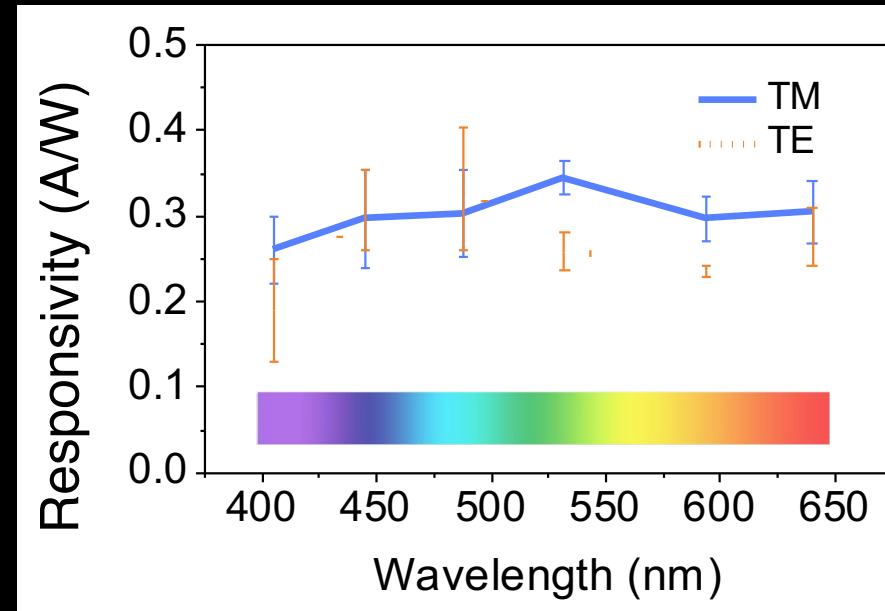
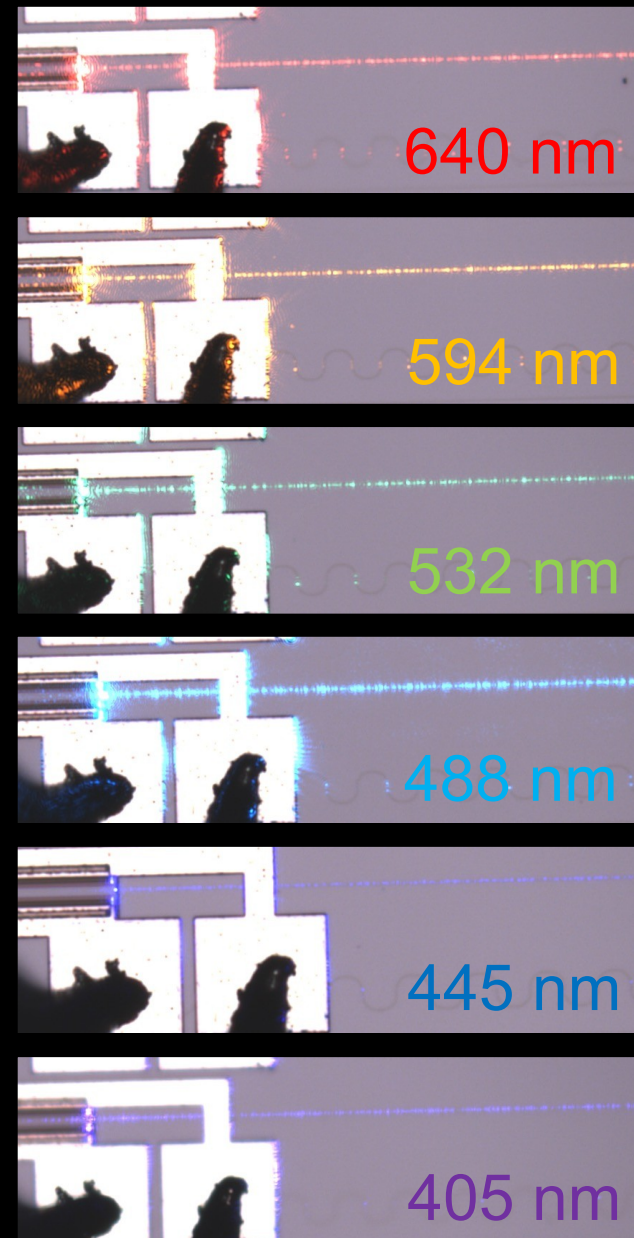
10%-90% Rise/fall time: 570/590us

Manuscript in preparation.

SiN-Si waveguide photodetectors

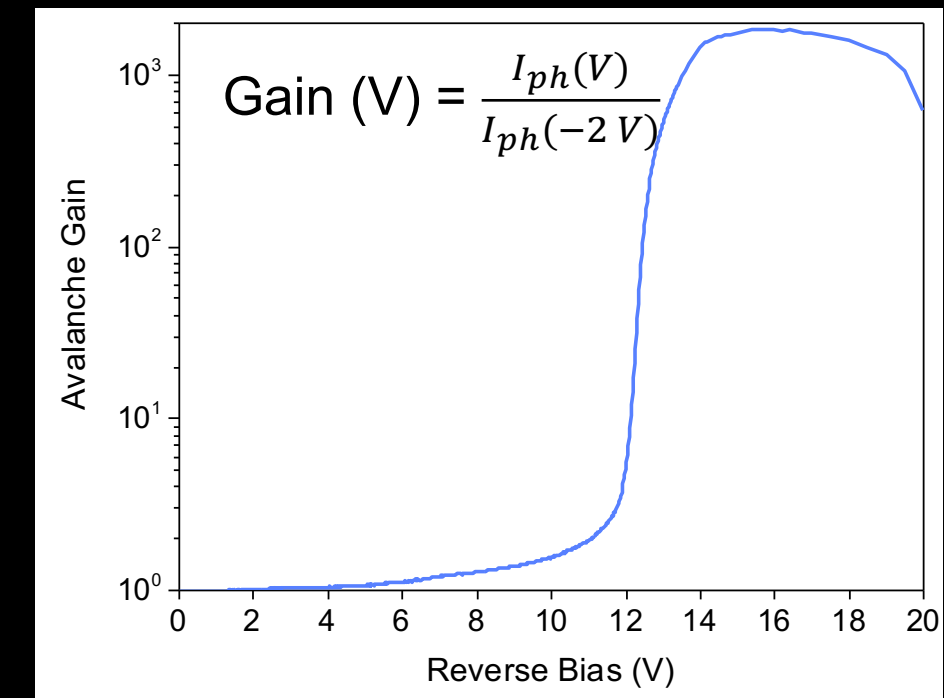


PIN diodes also



Dark current: 28pA @-2V
l = 50μm

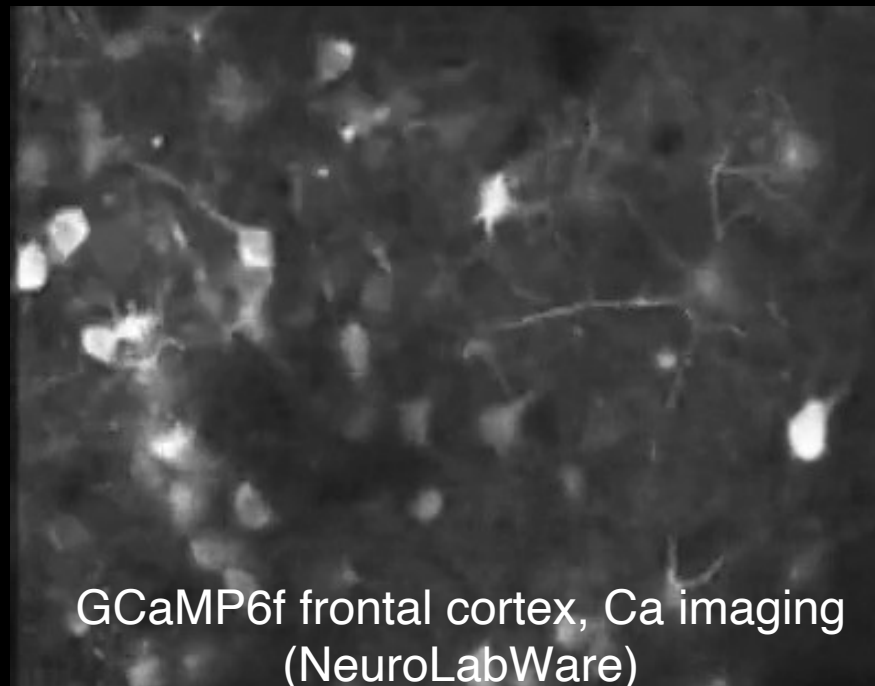
Avalanche Gain
(PN junction)



Avalanche gain up to 1800 at -17V
at $P_{in,PD}$ of -23.9 ± 0.3 dBm

Application: Light for brain activity mapping

- Genetically modified neurons actuated by or emit light

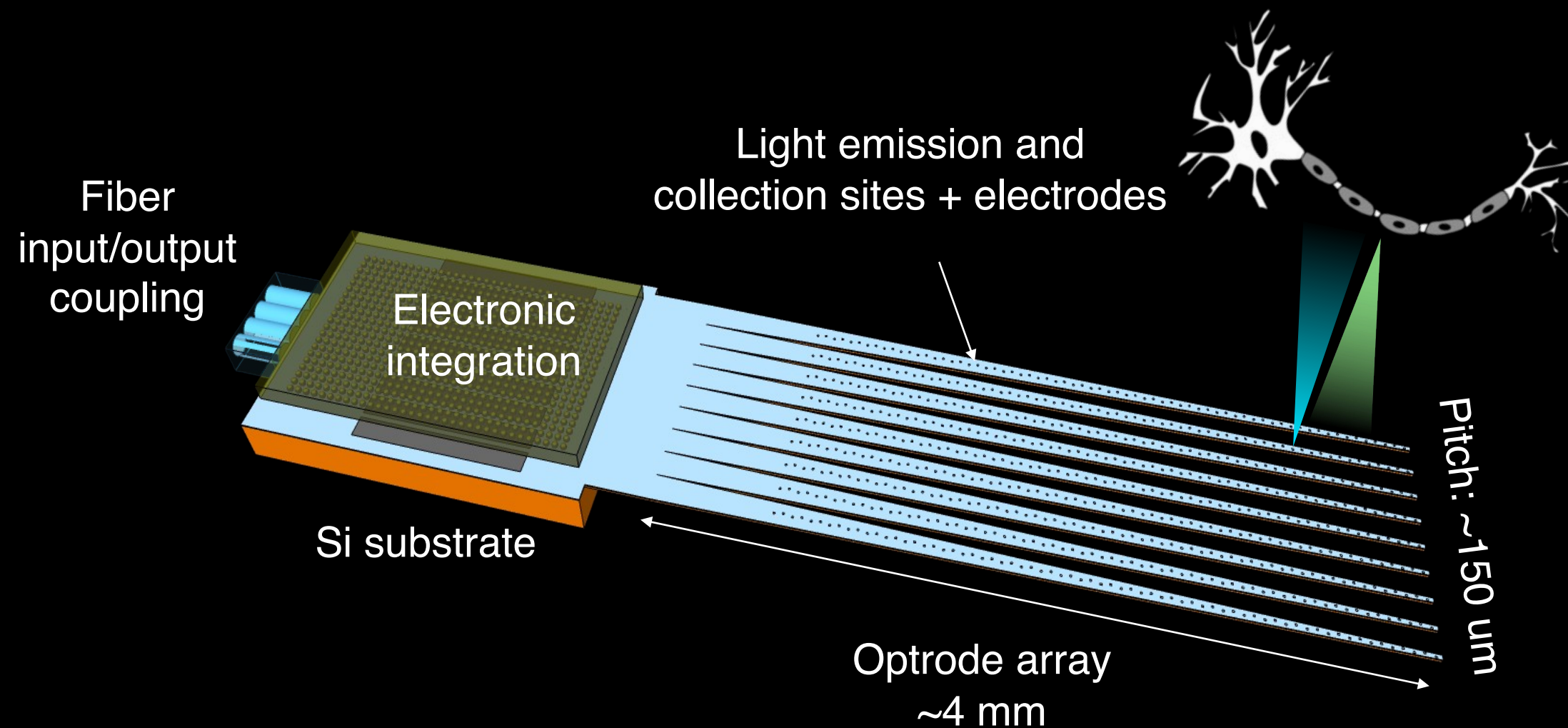


Functional optical (fluorescence) imaging
genetically encoded calcium or voltage indicators



Optogenetics
deterministic photo-actuation of neurons

Implantable neurophotonic probes



Overcome optical scattering limit for deep ($> \text{mm}$) brain access

Massively parallel interrogation with single neuron resolution

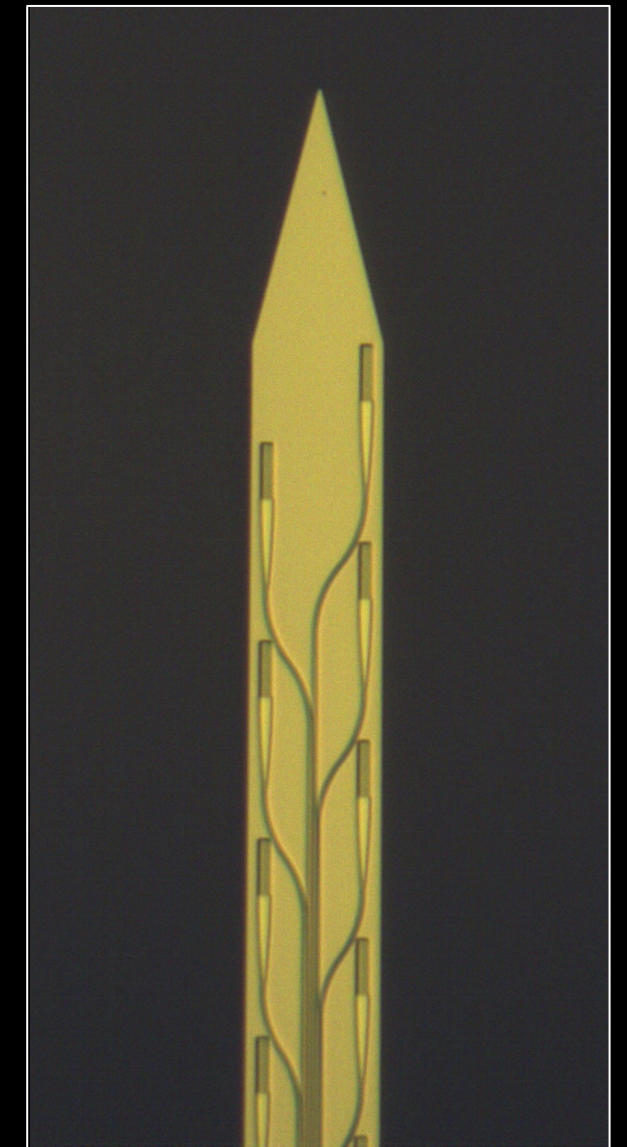
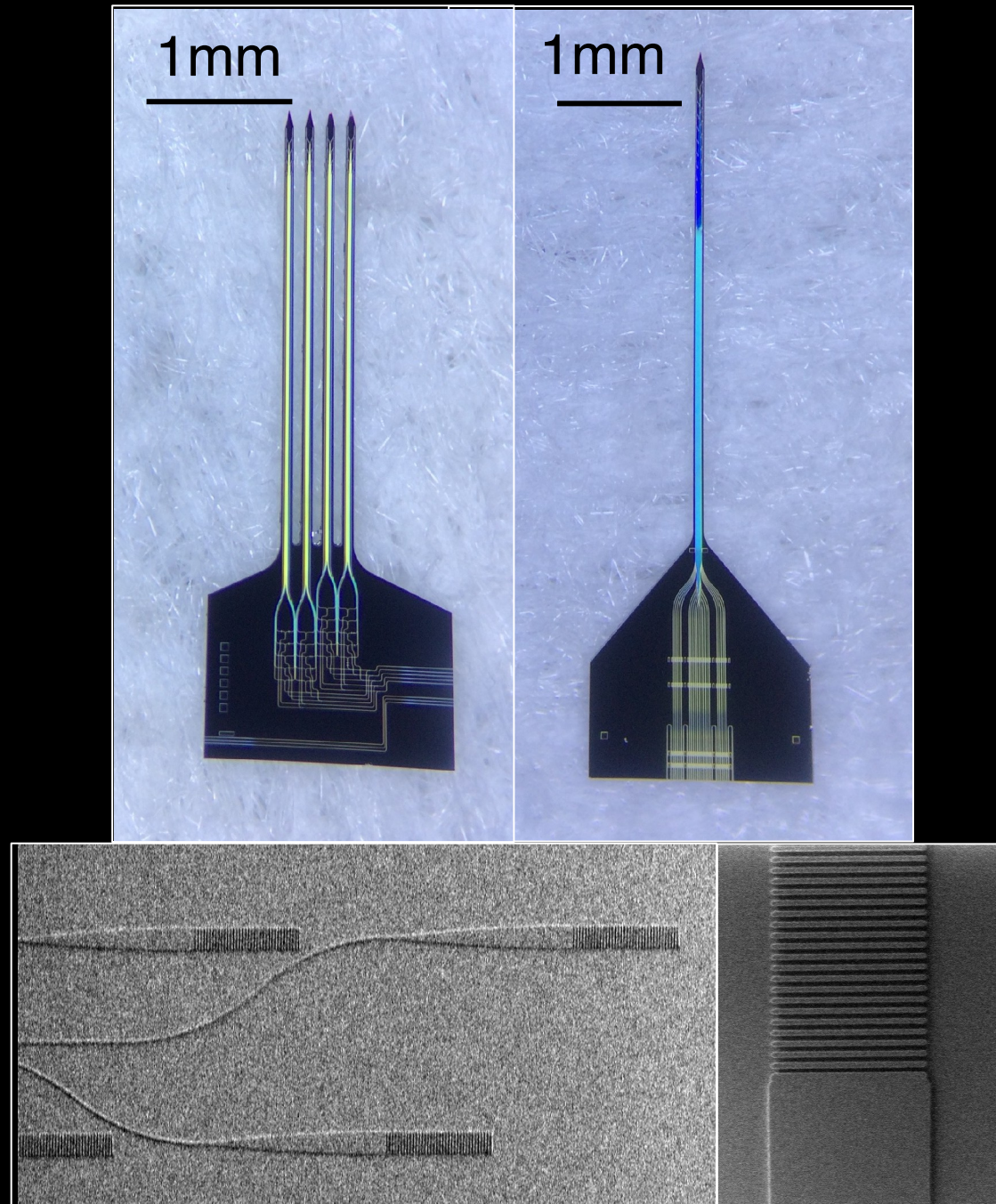
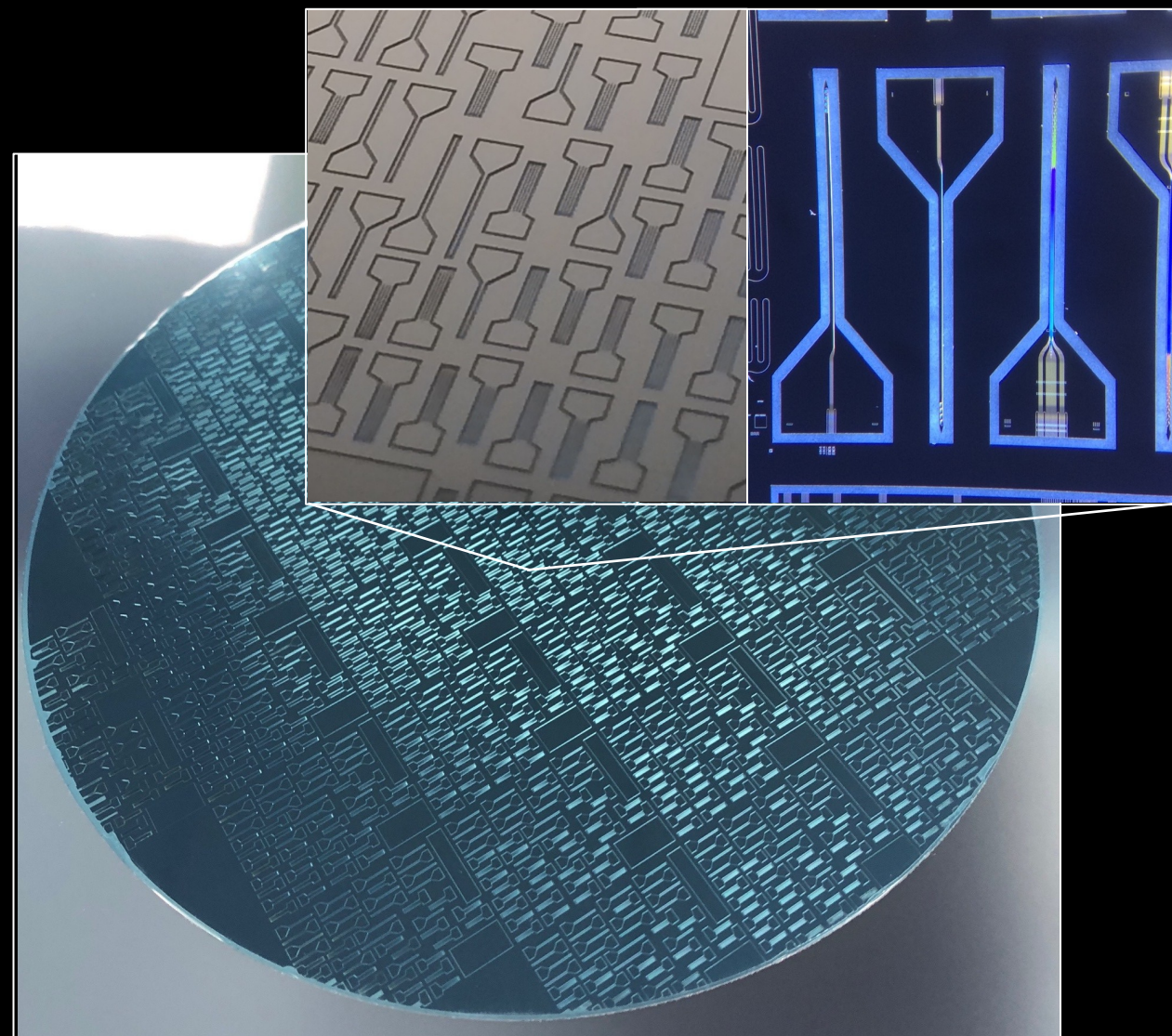
Foundry manufacturing for complexity and broad dissemination

Foundry-fabricated neurophotonic probes

Xianshu Luo
Patrick Lo



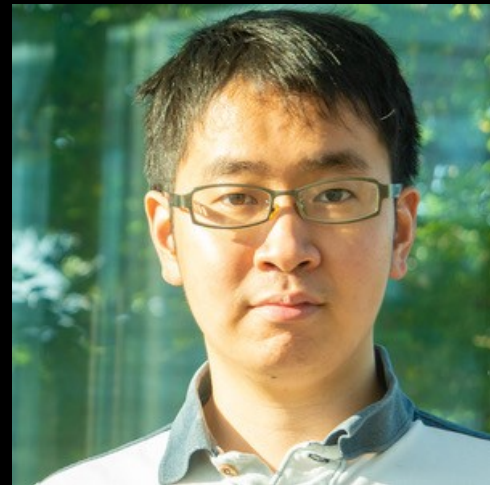
- 200mm (8") wafers, DUV lithography, full-wafer thinning
- >1600 probes on 1 wafer



Acknowledgment: Neuroprobe Team



Wesley Sacher



Fu-Der Chen



John Straguzzi



Hannes Wahn



Youngho Jung



Homeira Moradi
(Valiante-UHN)

alumni



Ilan Felts
Almog



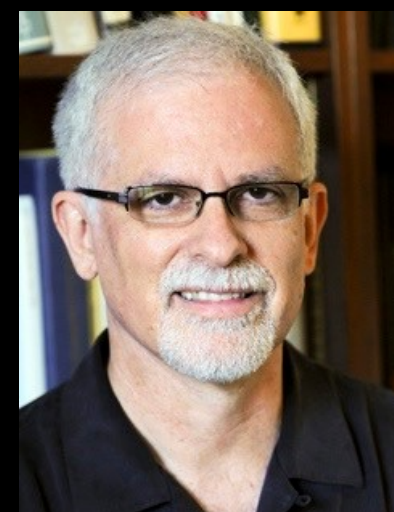
Thomas
Lordello



Taufik Valiante
(UHN, U of T)



Andres Lozano
(UHN, U of T)



Michael Roukes
(Caltech)

Laurent Moreaux
(Caltech)

Xinyu Liu
(Caltech)

Michael Chang
(Valiante-U of T, UHN)

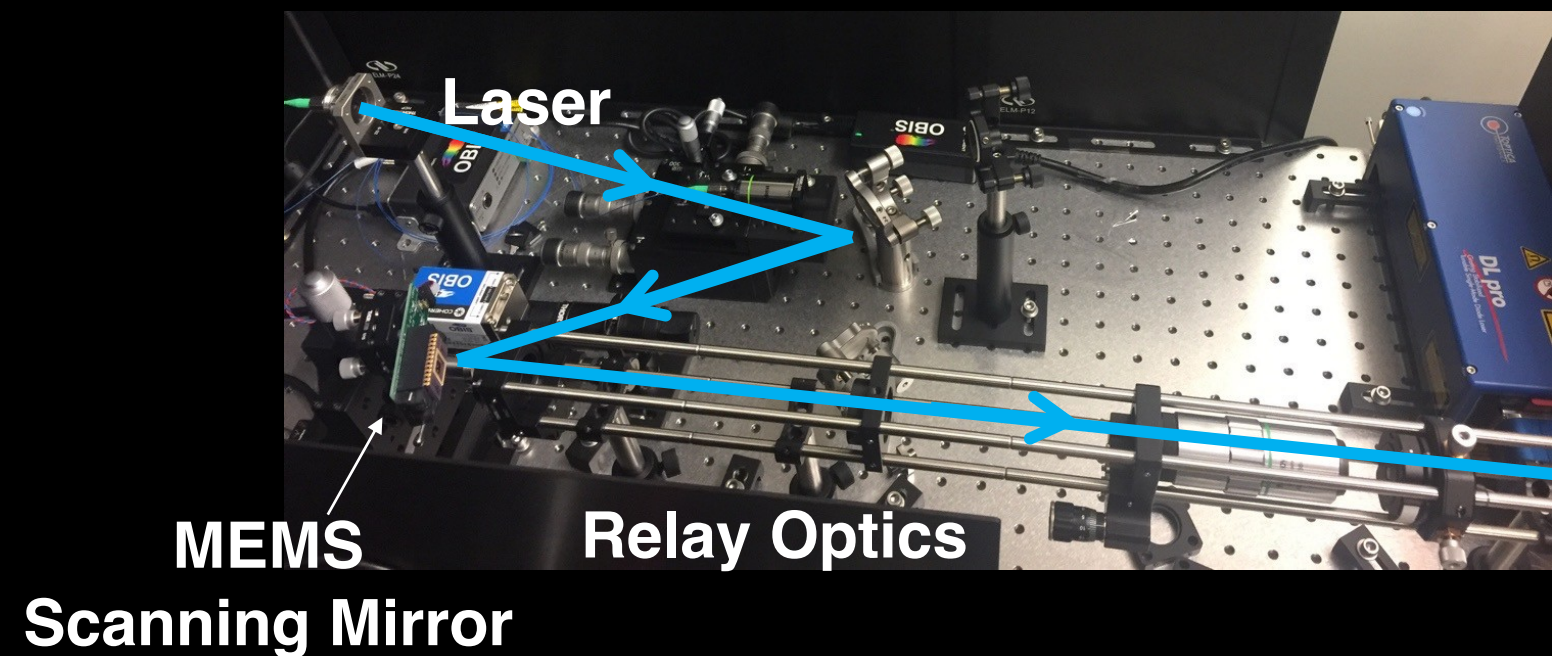
Azadeh Naderian
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Prajay Shah
(Valiante-UHN)

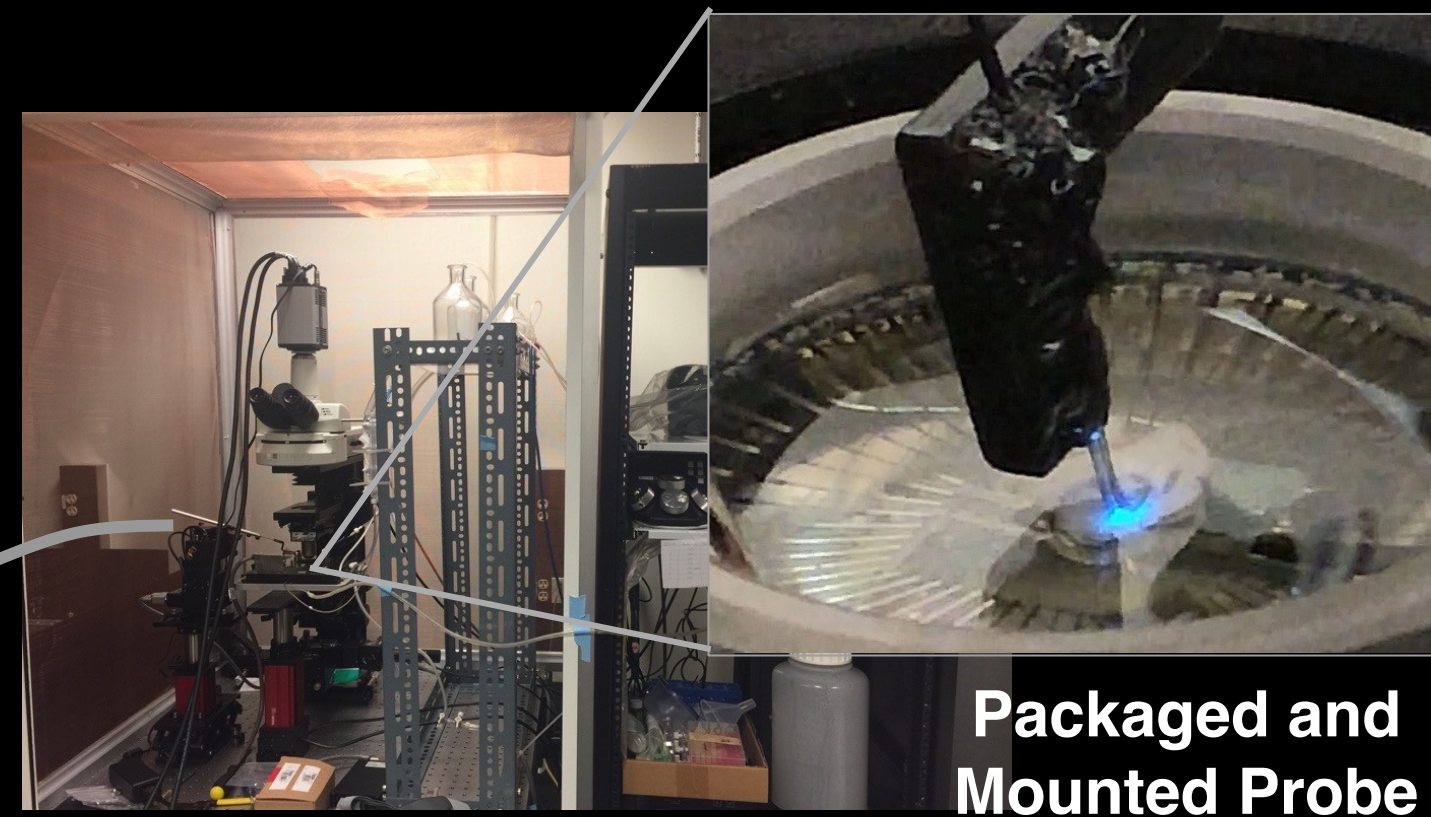
Anton Fomenko
(Lozano-U of T, UHN)

Sara Mahallati
(Valiante-U of T, UHN)

Approach: Passive neurophotonic probe with spatial addressing



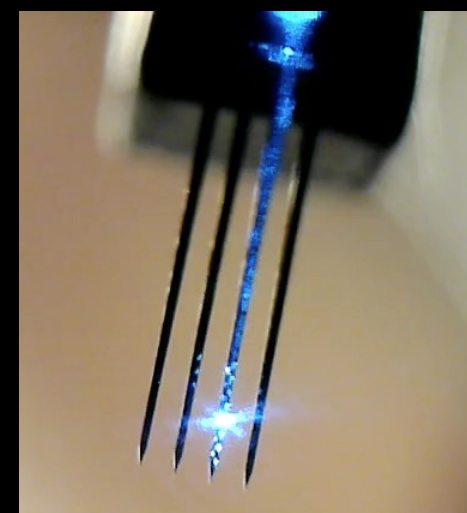
Fiber Bundle



Fiber Bundle Cross-Section



with Auto-Pix:
the Pixel Dance!

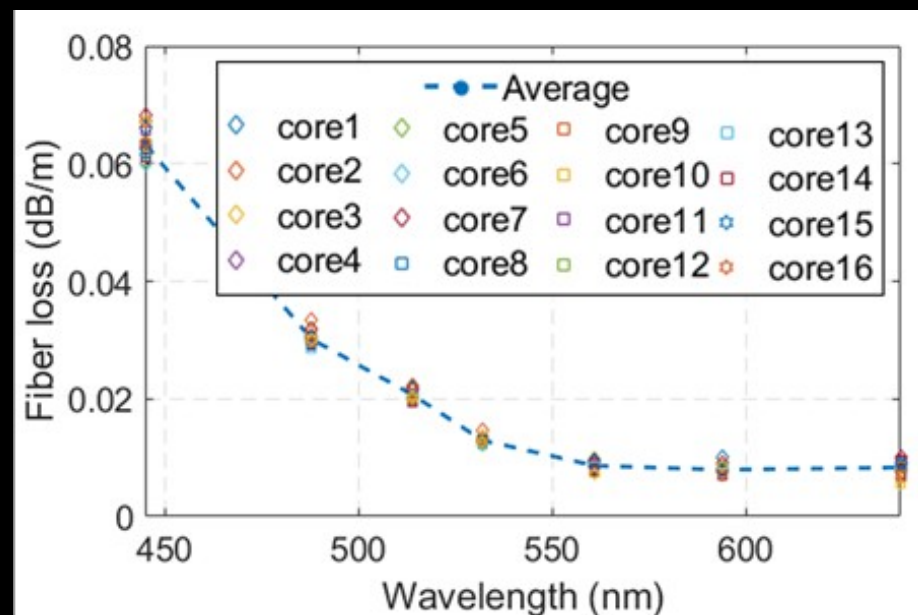
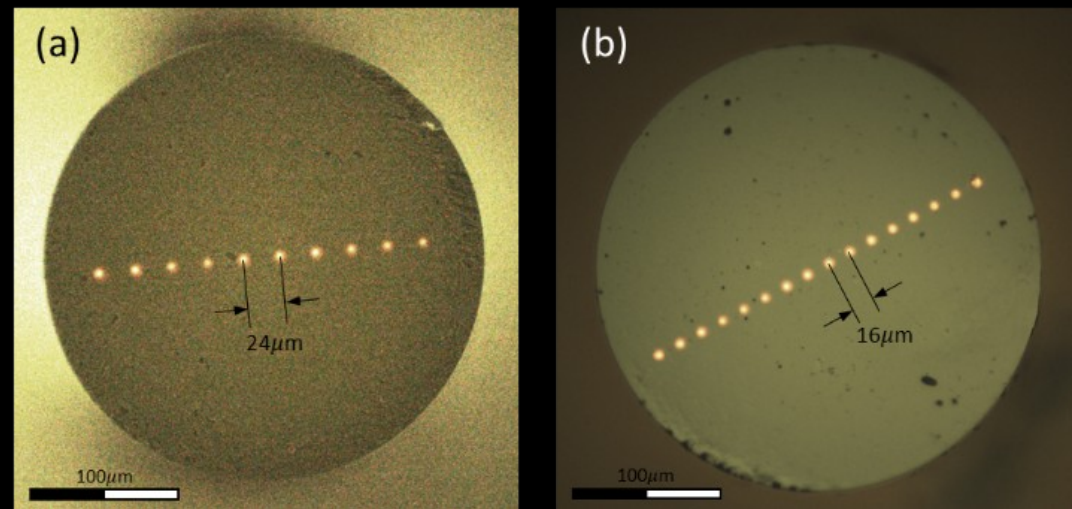


Improvements: Custom multi-core optical fibers & Mini-Scan

- 10 and 16 single-mode cores
 - Nominal pitch: 24 μ m, 16 μ m
 - Fiber diameter: 300 μ m

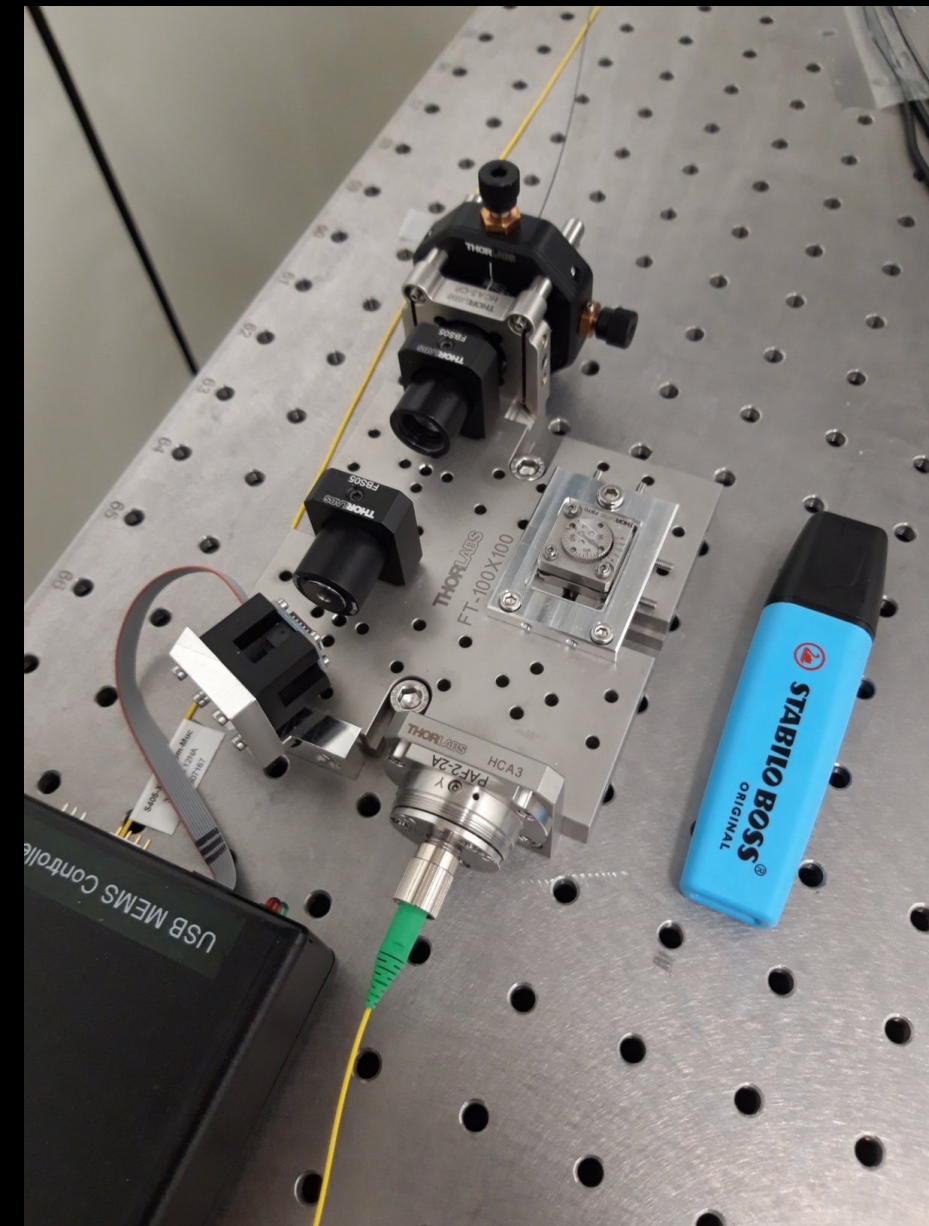
CORNING

Kevin Bennett



Fiber loss

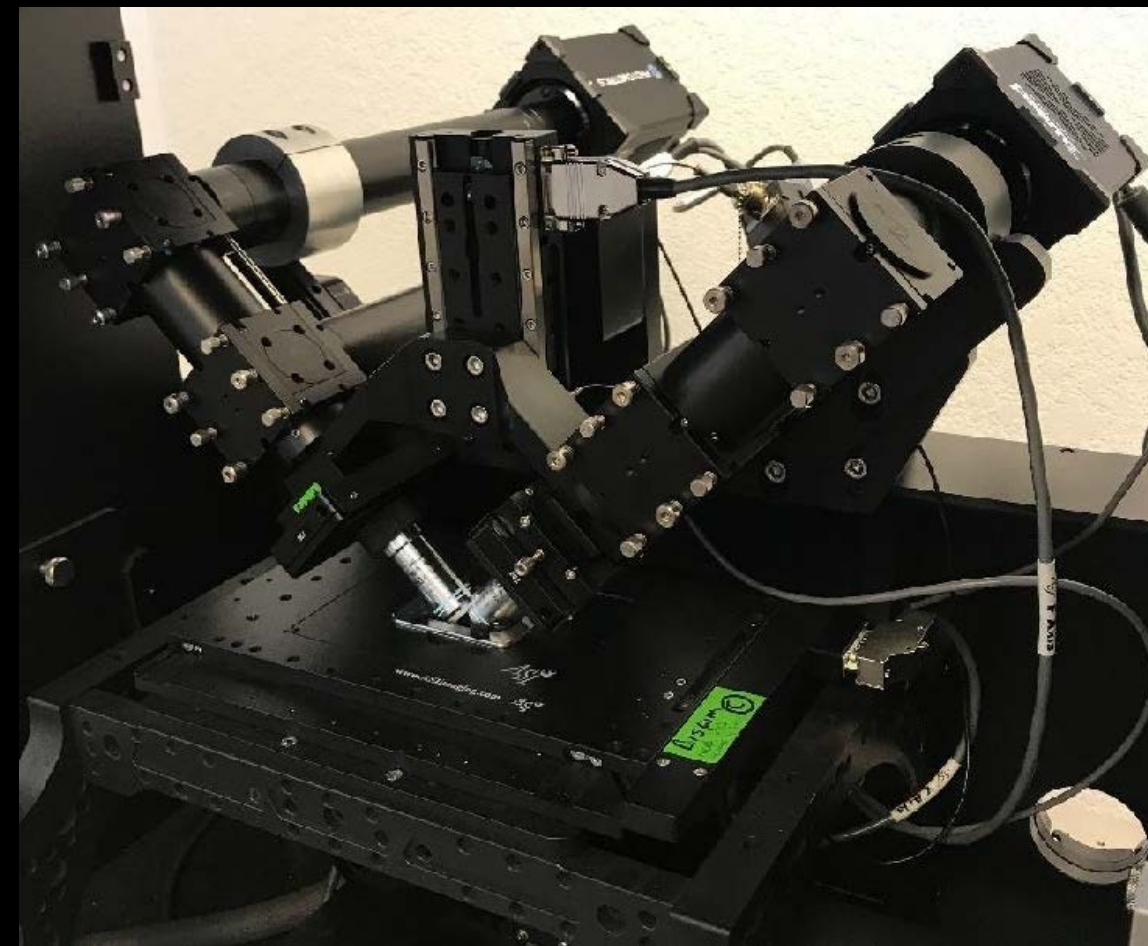
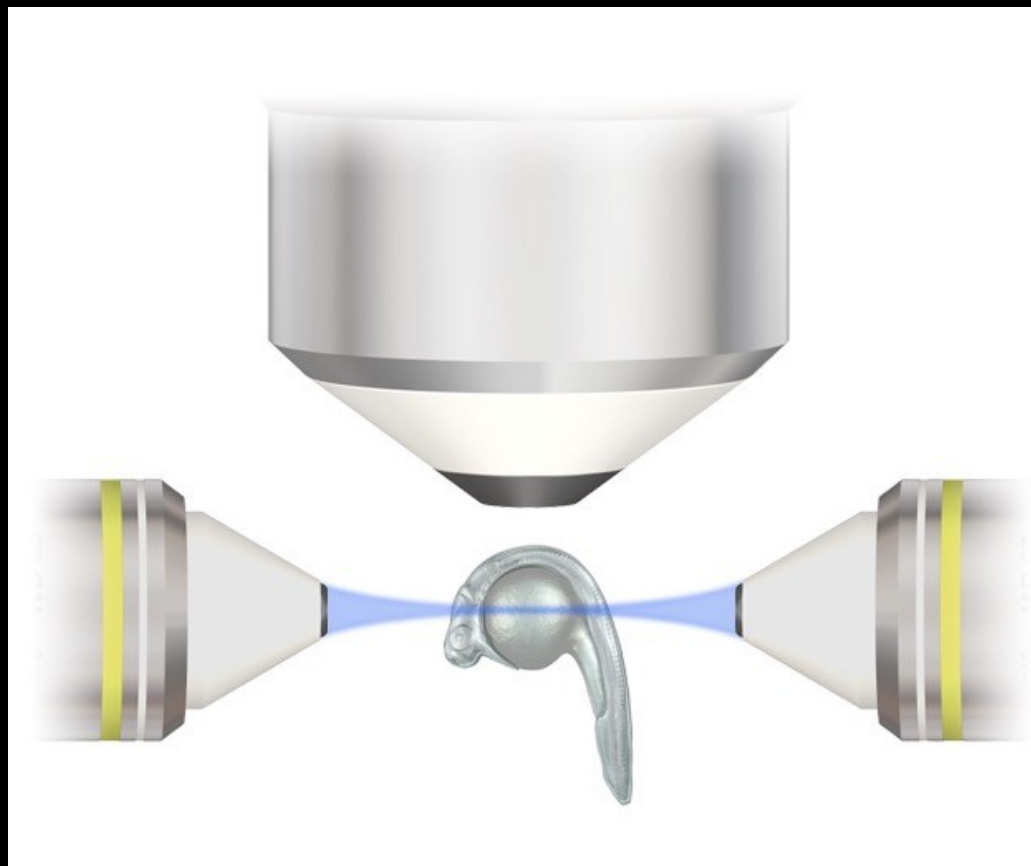
Miniaturized scanning unit



Lightsheet fluorescence microscopy

- Selective Plane Illumination Microscopy
- Image 1 plane at a time \Rightarrow Large volume imaging
- So far, only applies to transparent small organisms due to bulkiness of the optics

Excitation



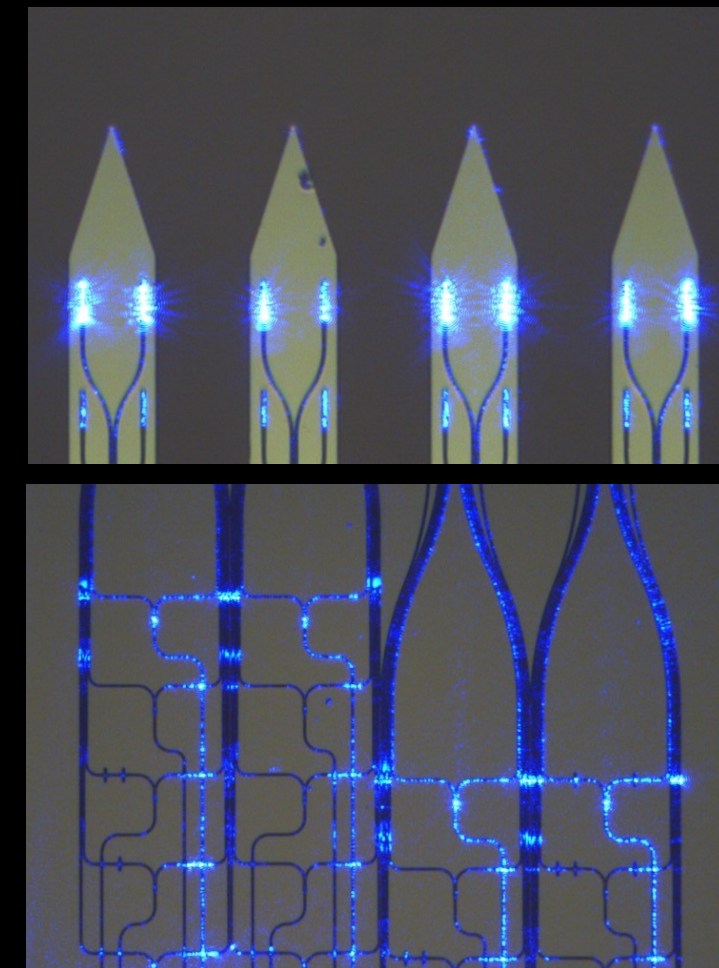
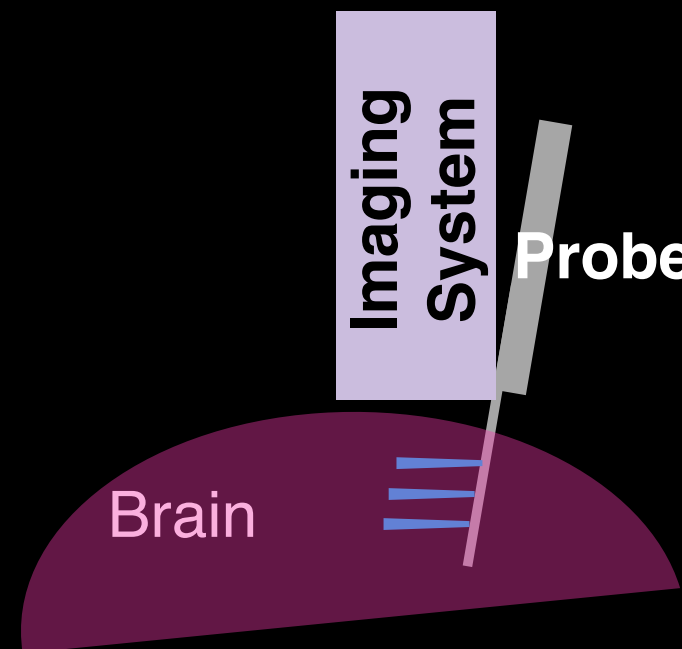
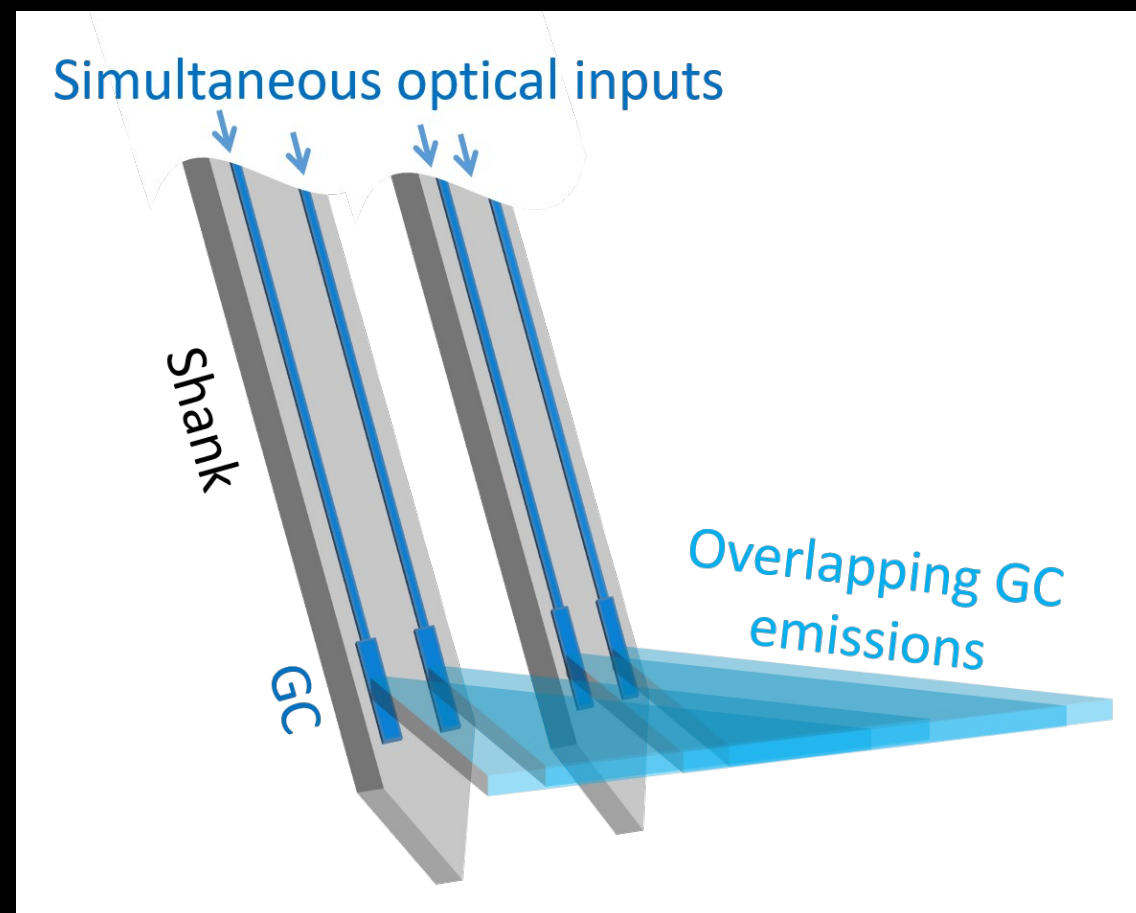
<https://www.microscopyu.com/techniques/light-sheet/light-sheet-fluorescence-microscopy>

<https://www.photometrics.com/applications/appnotes/dispim>

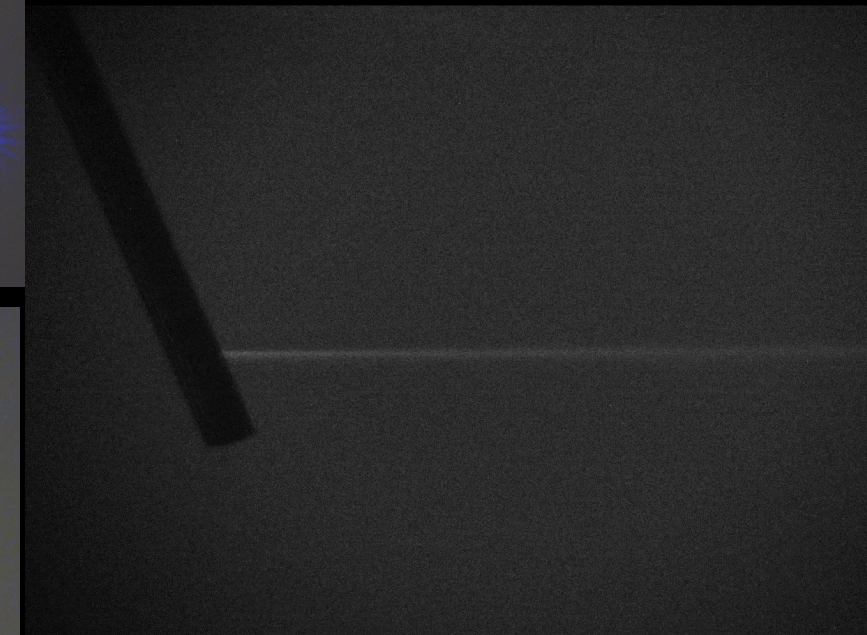
Lightsheet imaging neurophotonic probe

Michael Roukes Taufik Valiante, Andres Lozano

- Synthesize lightsheet from multiple grating couplers
- Implantable miniature light source \Rightarrow lightsheet microscopy in non-transparent organisms

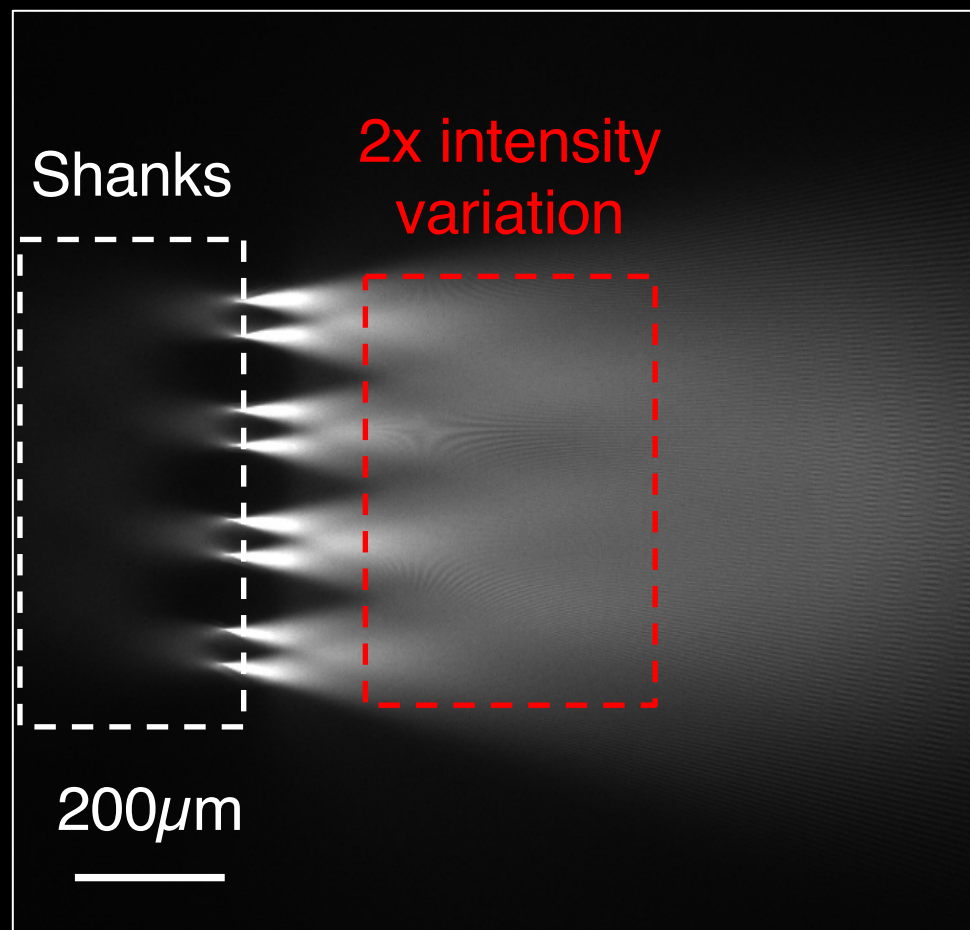


Fluorescein side profile



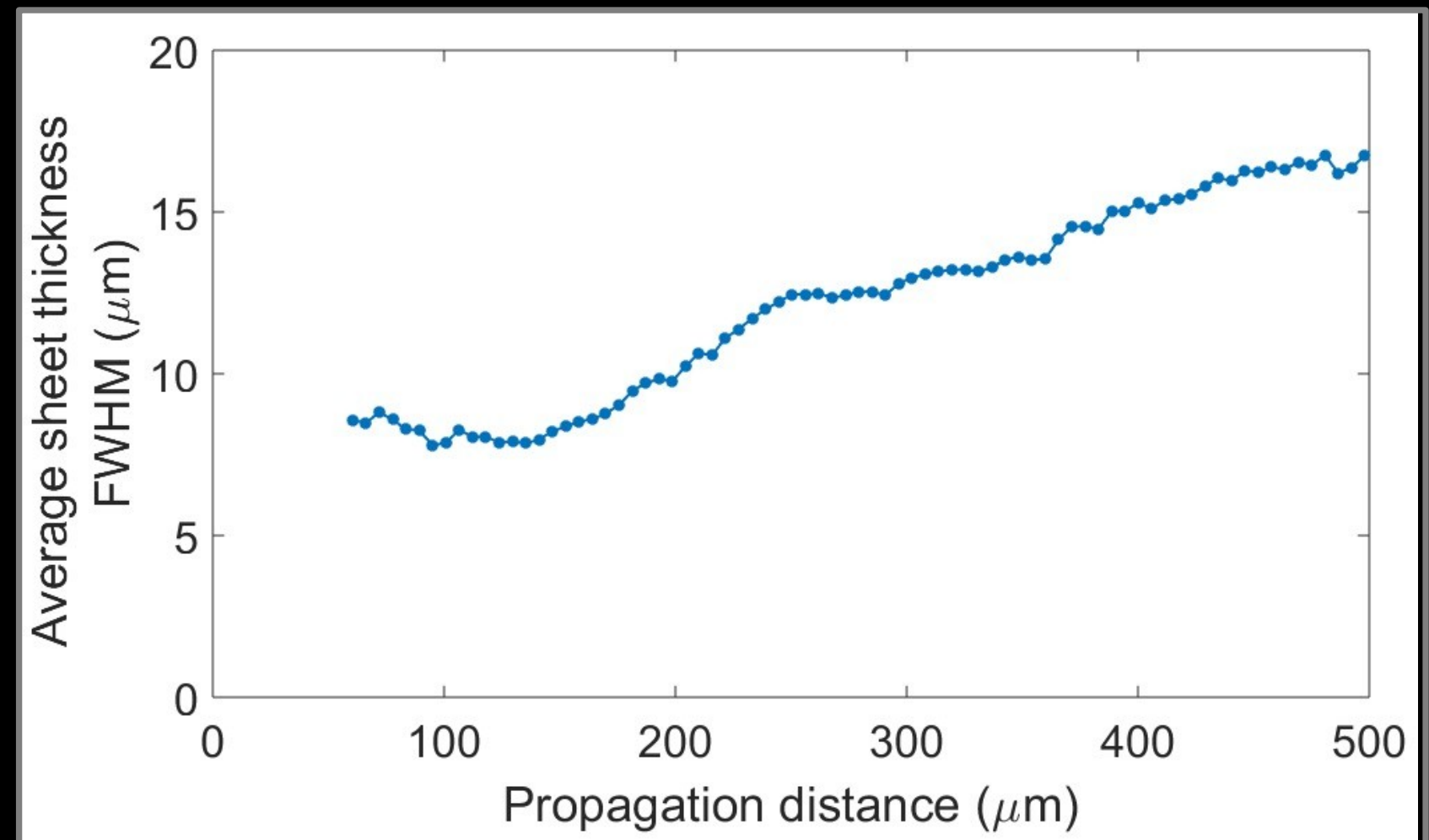
Light-sheet characterization

Top-down image
in fluorescein solution



In scattering media, uniformity is higher

Extracted average sheet thickness in free space
from imaging a fluorescent thin film



Fixed Tissue validation

- ≈ 1 mm thick fixed slice from Thy1-GCaMP6s transgenic mouse
- Dentate gyrus, $< 100\mu\text{m}$ depth

Light-sheet probe illumination

3-4x average contrast enhancement for neurons

200 μm

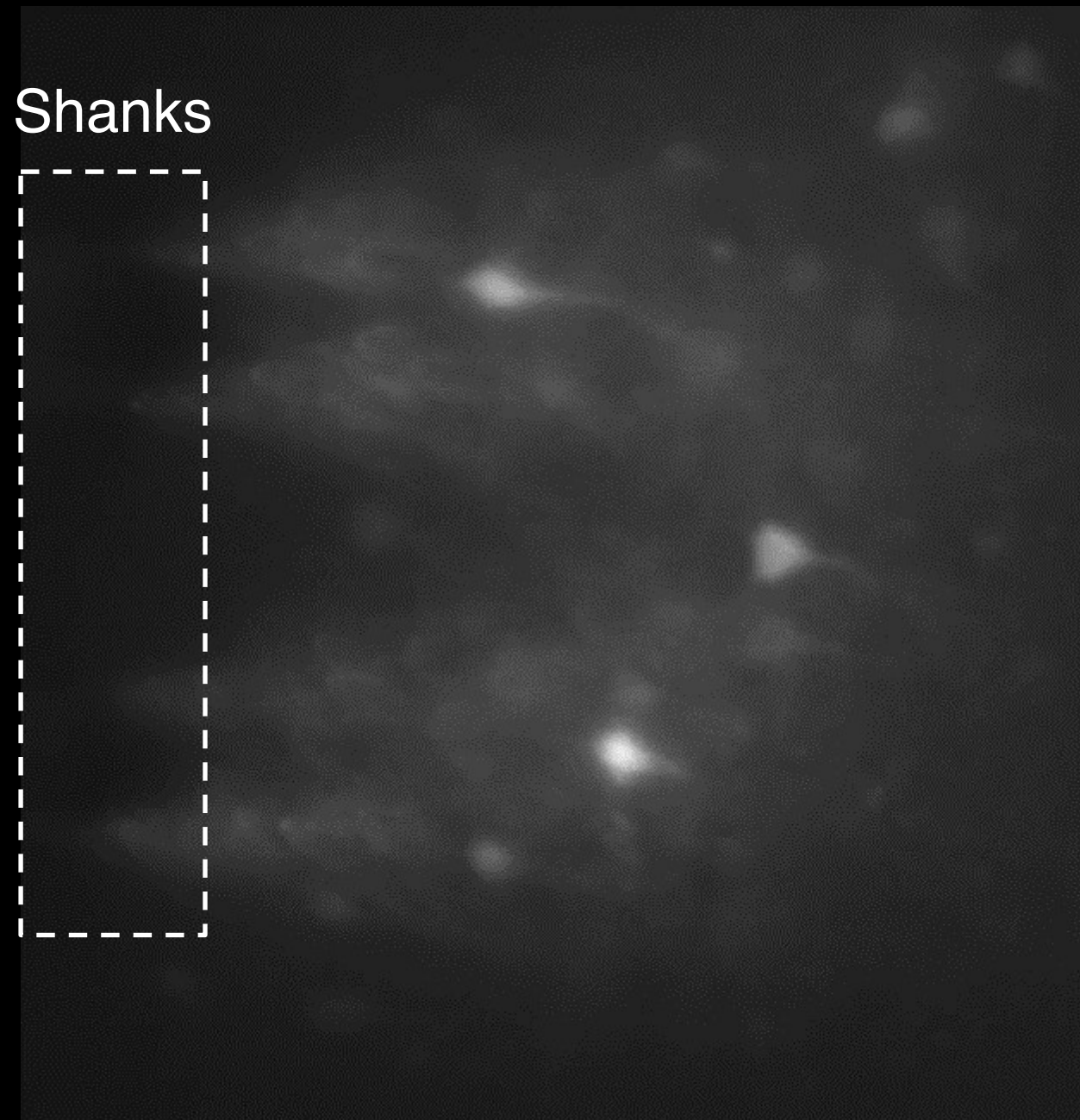


Epifluorescence

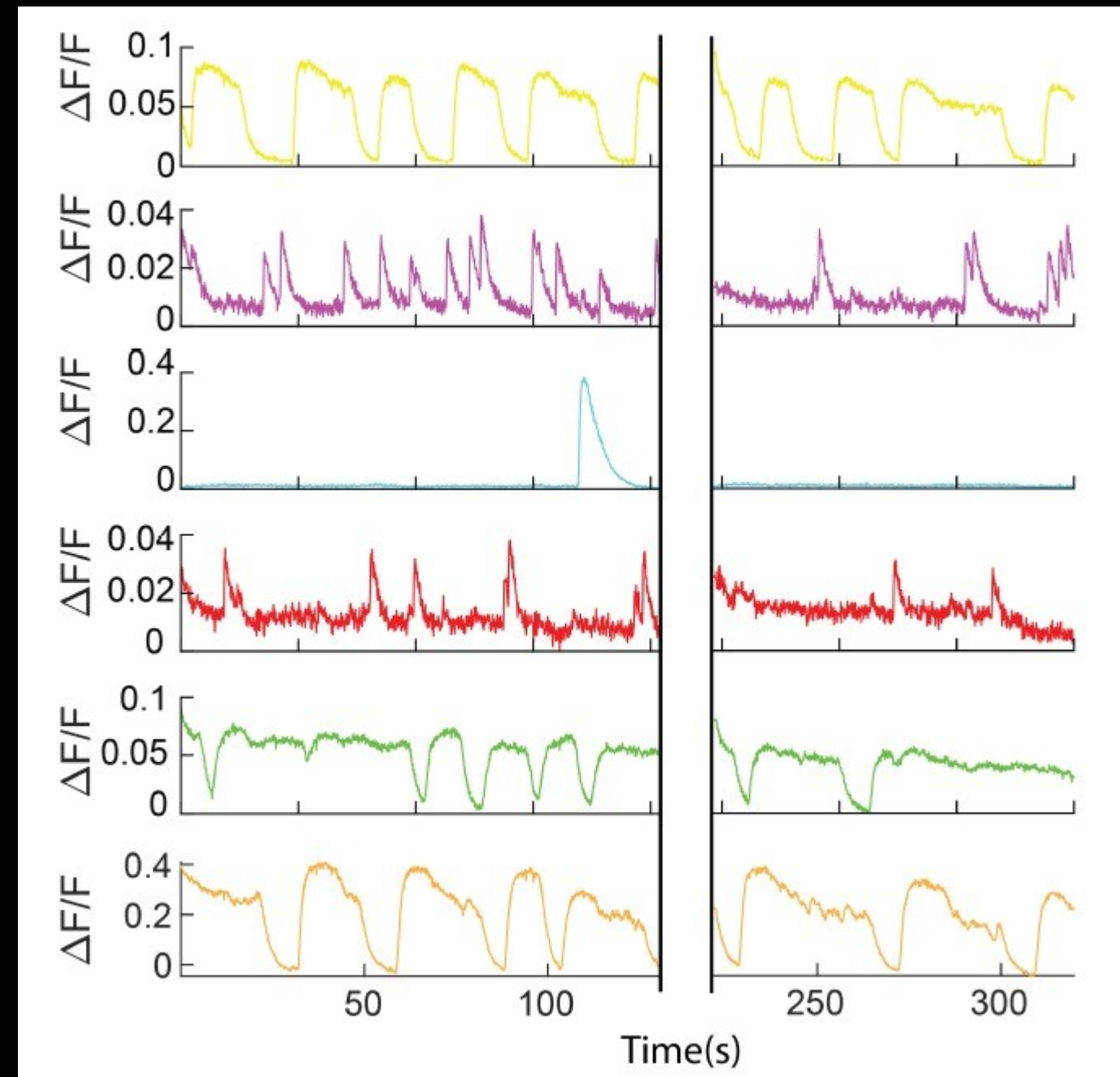


Brain slice functional imaging

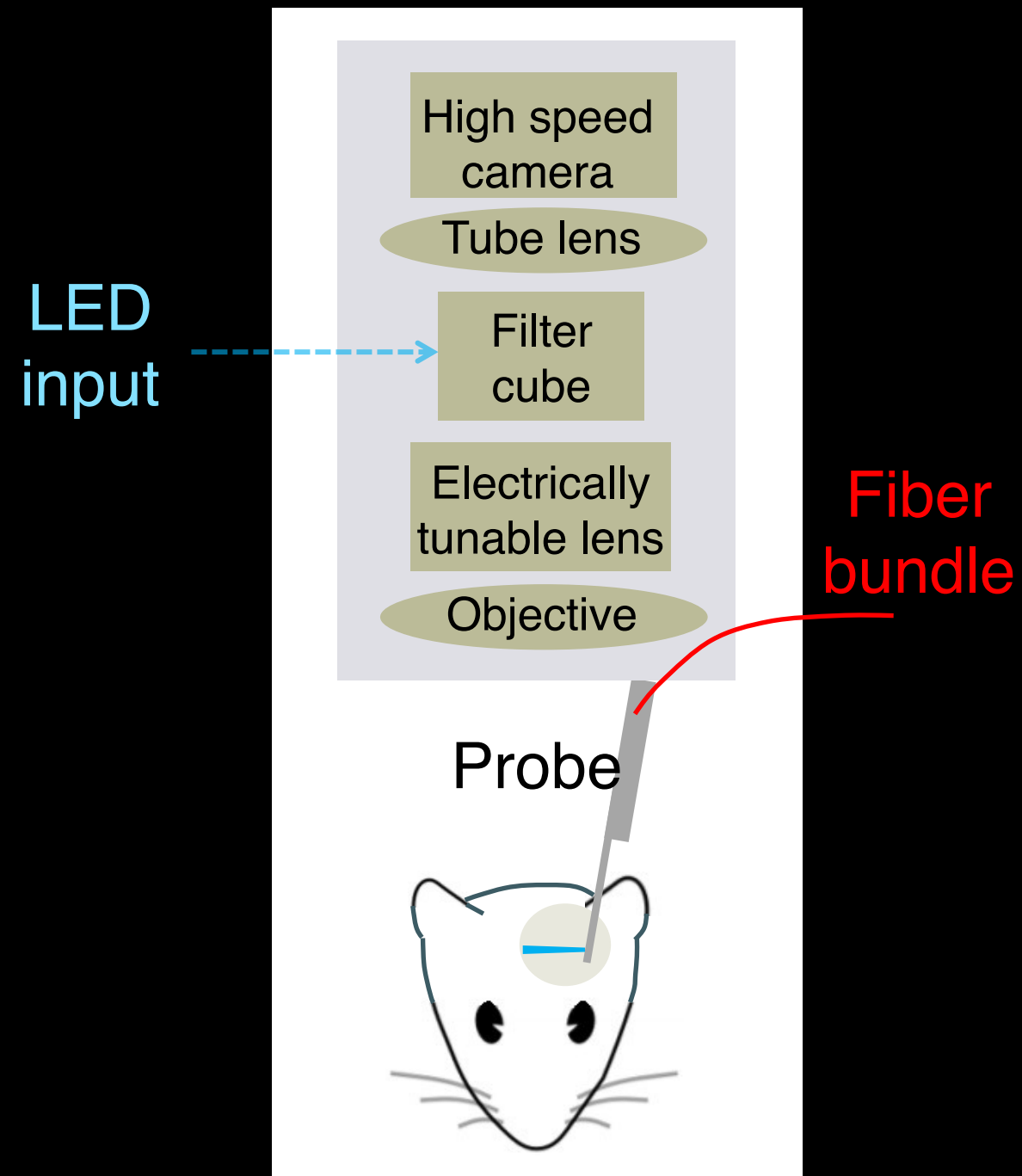
- $\approx 450\mu\text{m}$ thick perfused cortical brain slice from Thy1-GCaMP6s transgenic mouse.



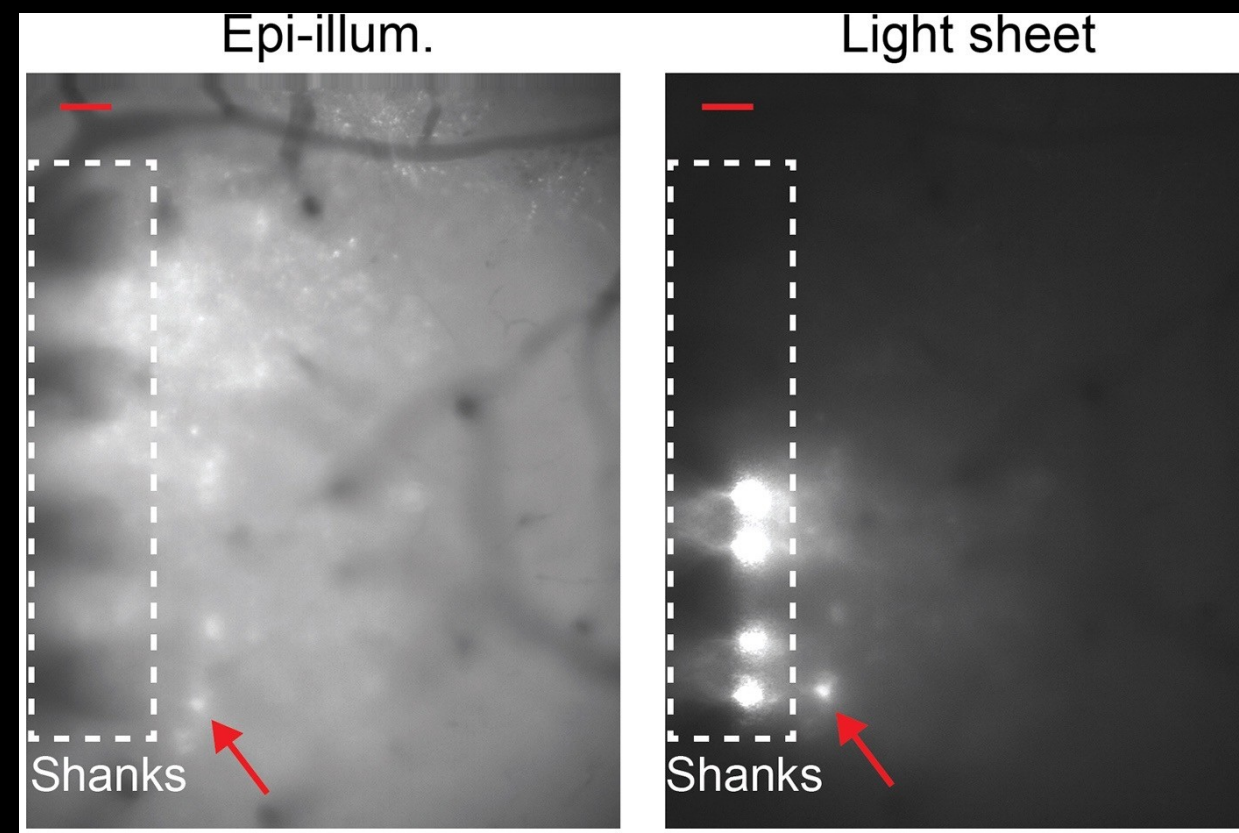
Video accelerated 10x



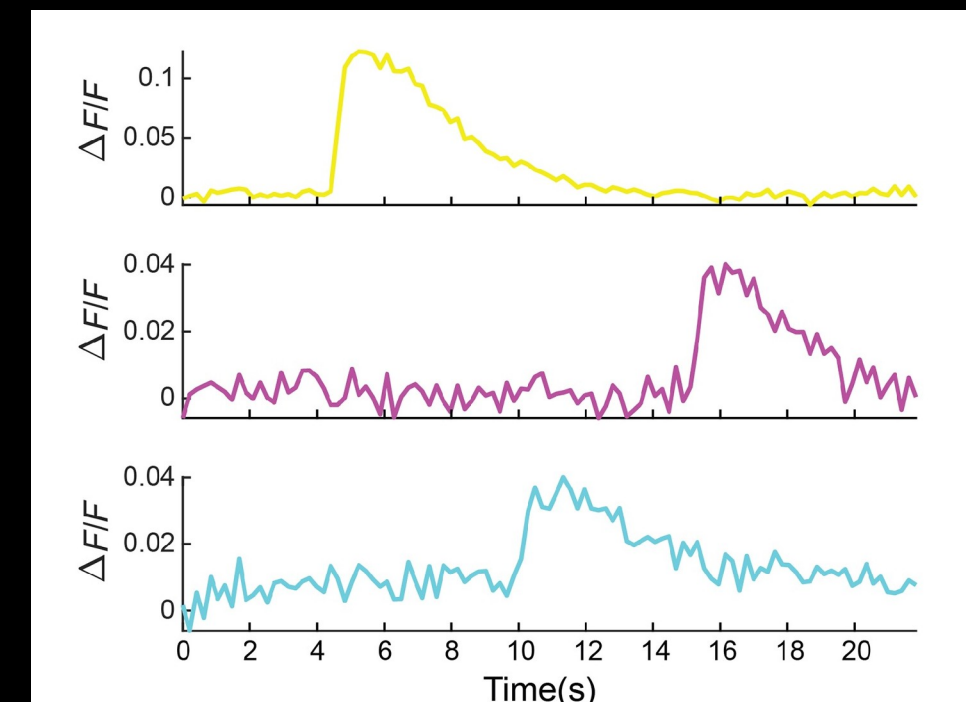
In vivo experiments



In vivo Comparison in the same setup



Activity imaged



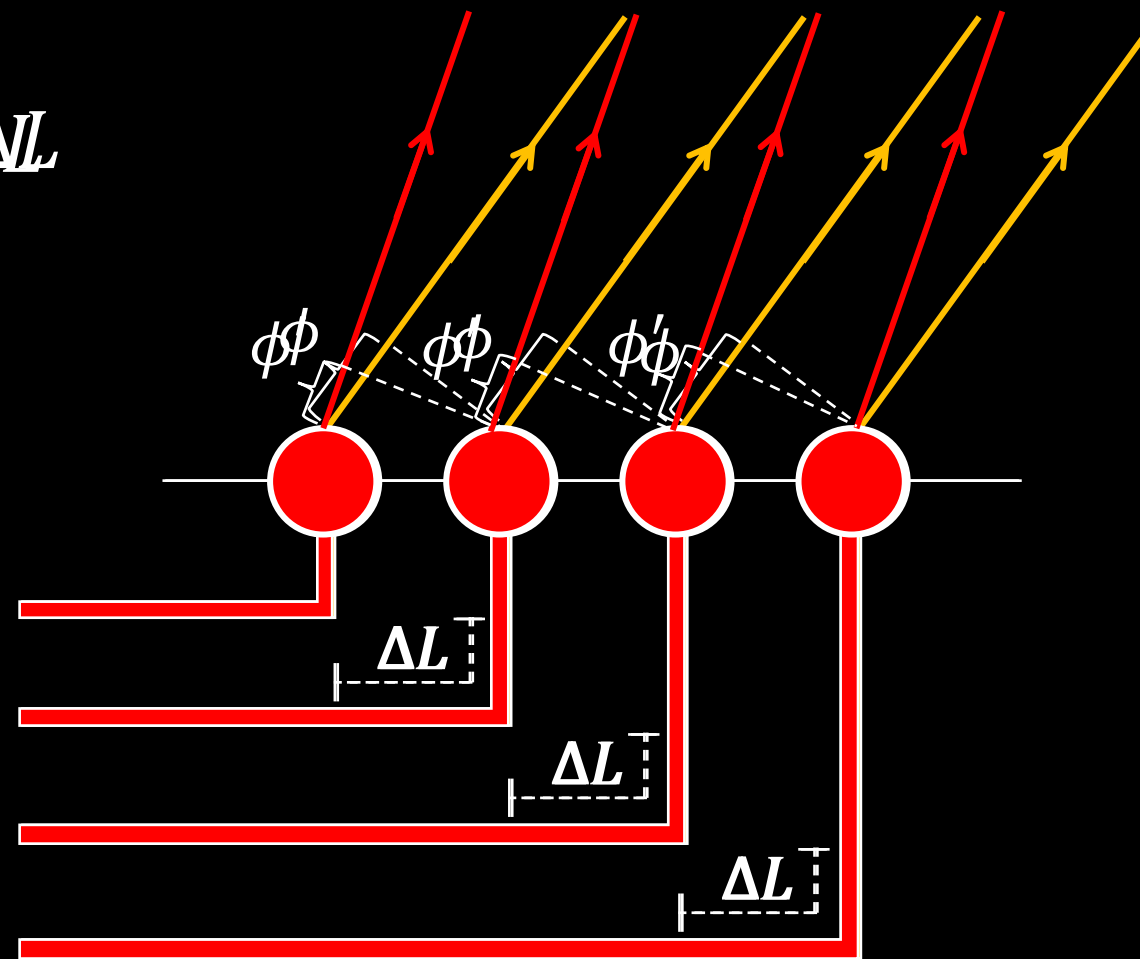
- Anesthetized Thy1-GCaMP6s mouse
- Parietal cortex, $< 200\mu\text{m}$ sheet depth

Beam-steering neurophotonic probes

- High spatial resolution optogenetics and functional optical imaging
- Miniature **optical phased array**; No moving parts in tissue

$$\phi' = \frac{2\pi m}{\lambda'} \Delta L$$

Beam-steering by
wavelength tuning
(external cavity single-
mode laser)

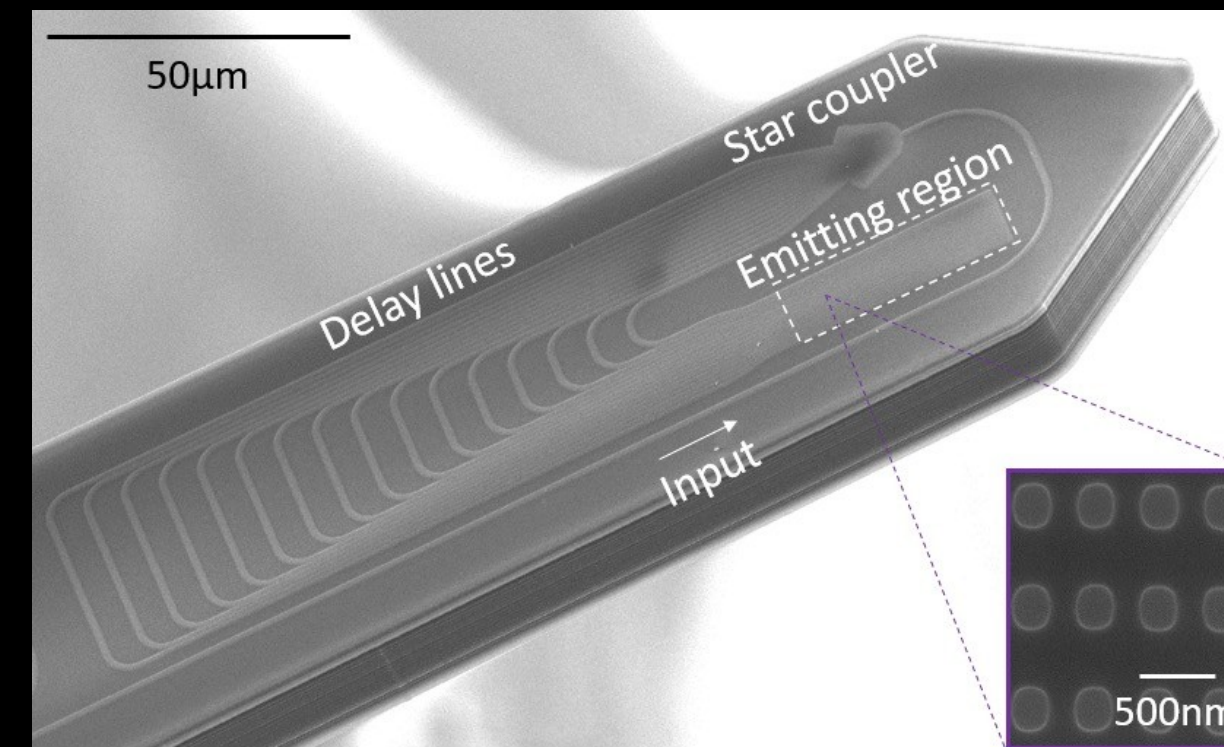
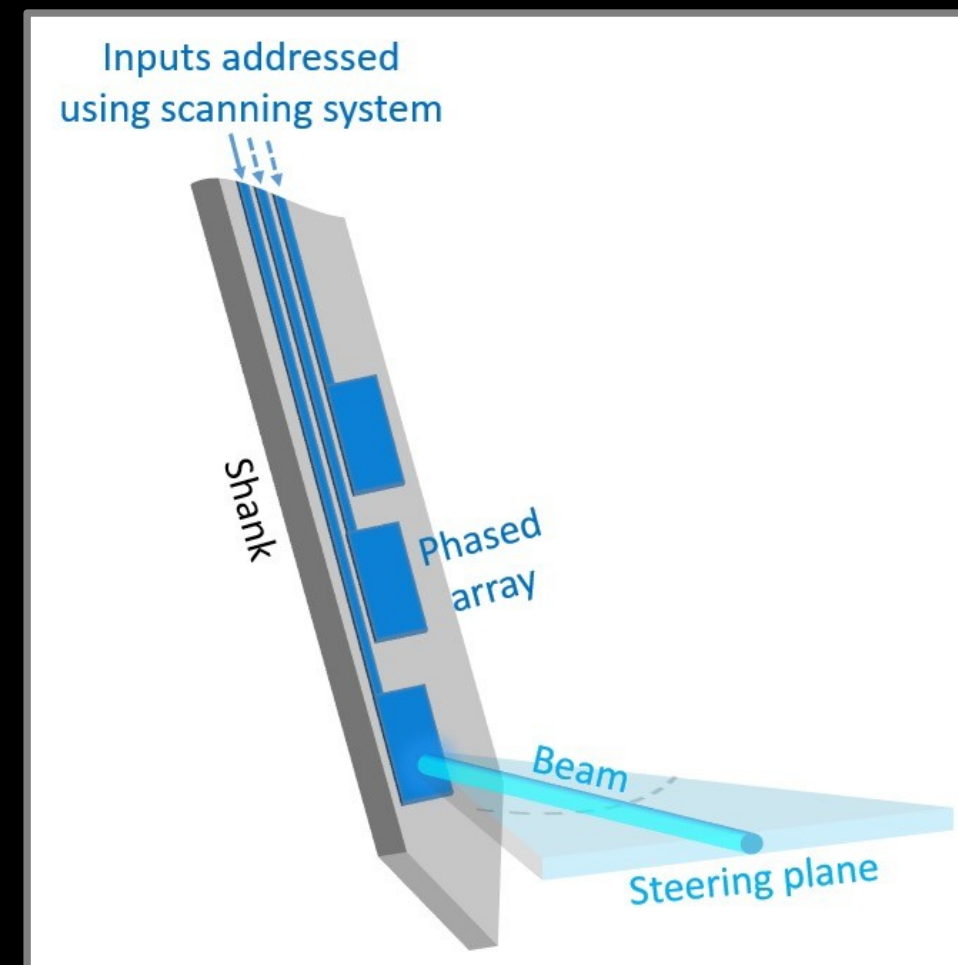
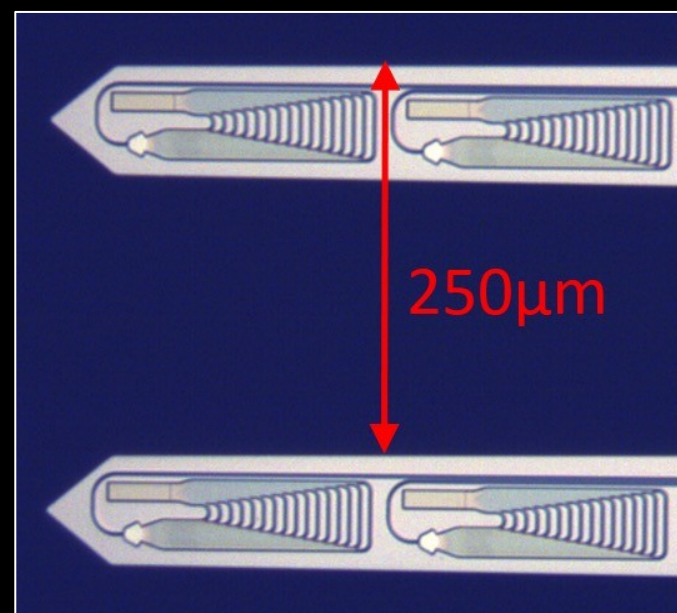
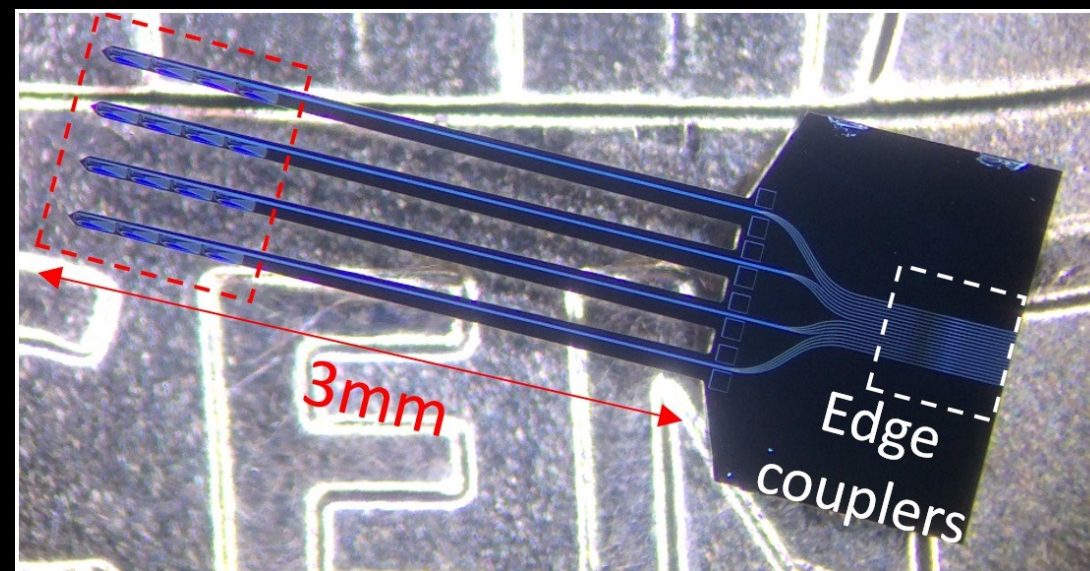


Beam-steering neurophotonic probes

Michael Roukes

Taufik Valiante

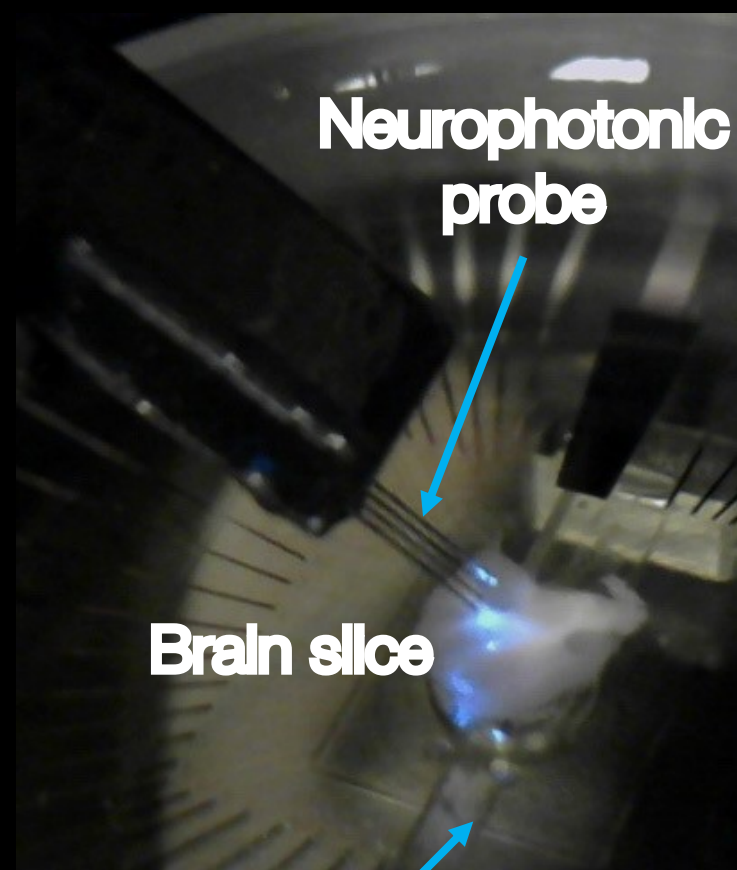
- Gratings as light emitters



In vitro validation

Optogenetic stimulation

- VGAT-ChR2-EYFP: ChR2 expressed in interneurons
- Very low power: max. laser output power $\sim 10\text{mW}$

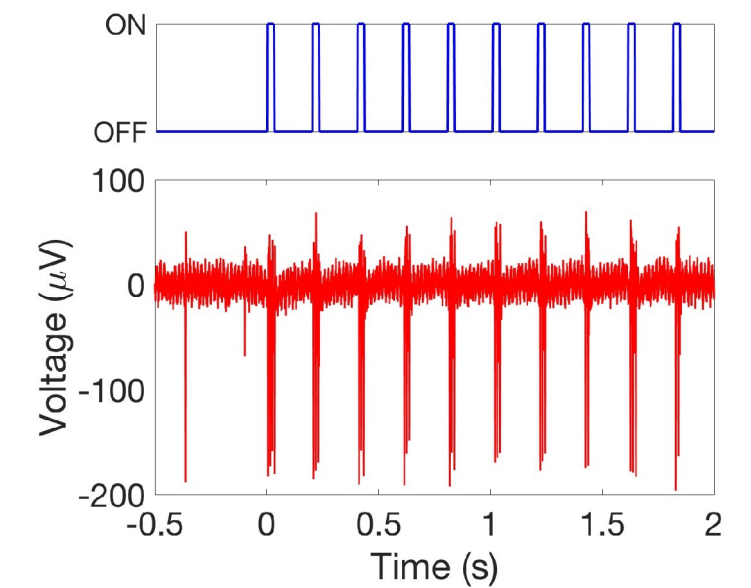
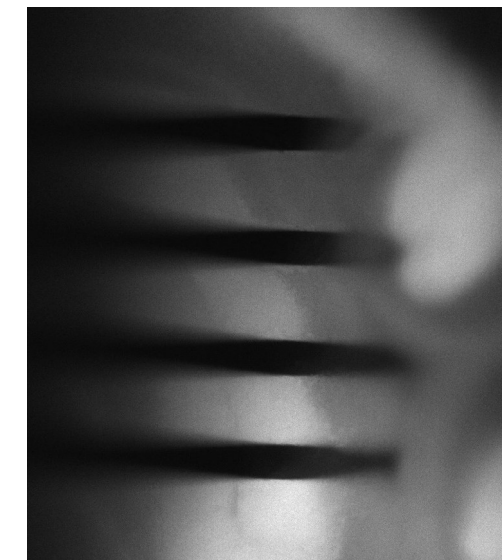


Microelectrode array (MEA)
100 μm pitch

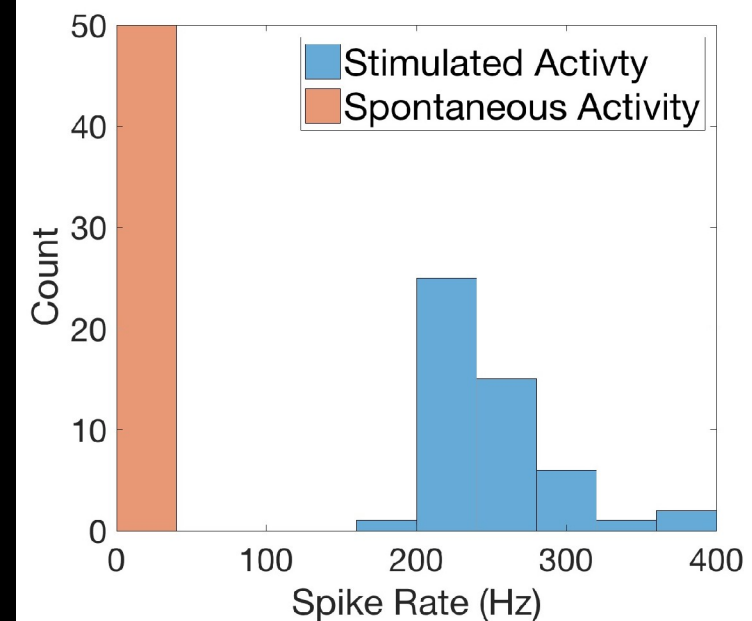
100 μm YFP

Beam-forming possible in tissue!

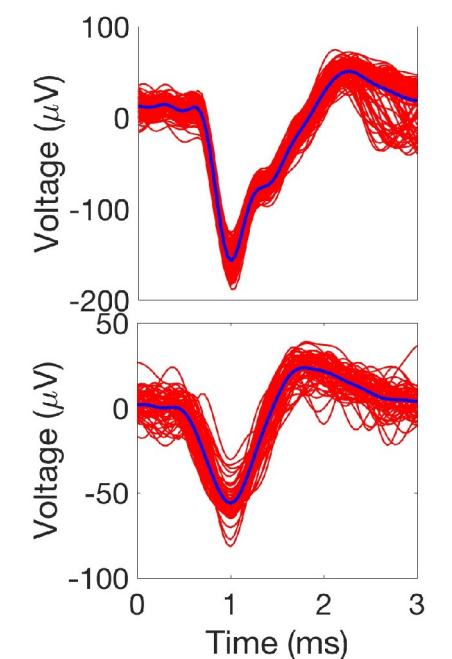
Cerebellum Molecular Layer



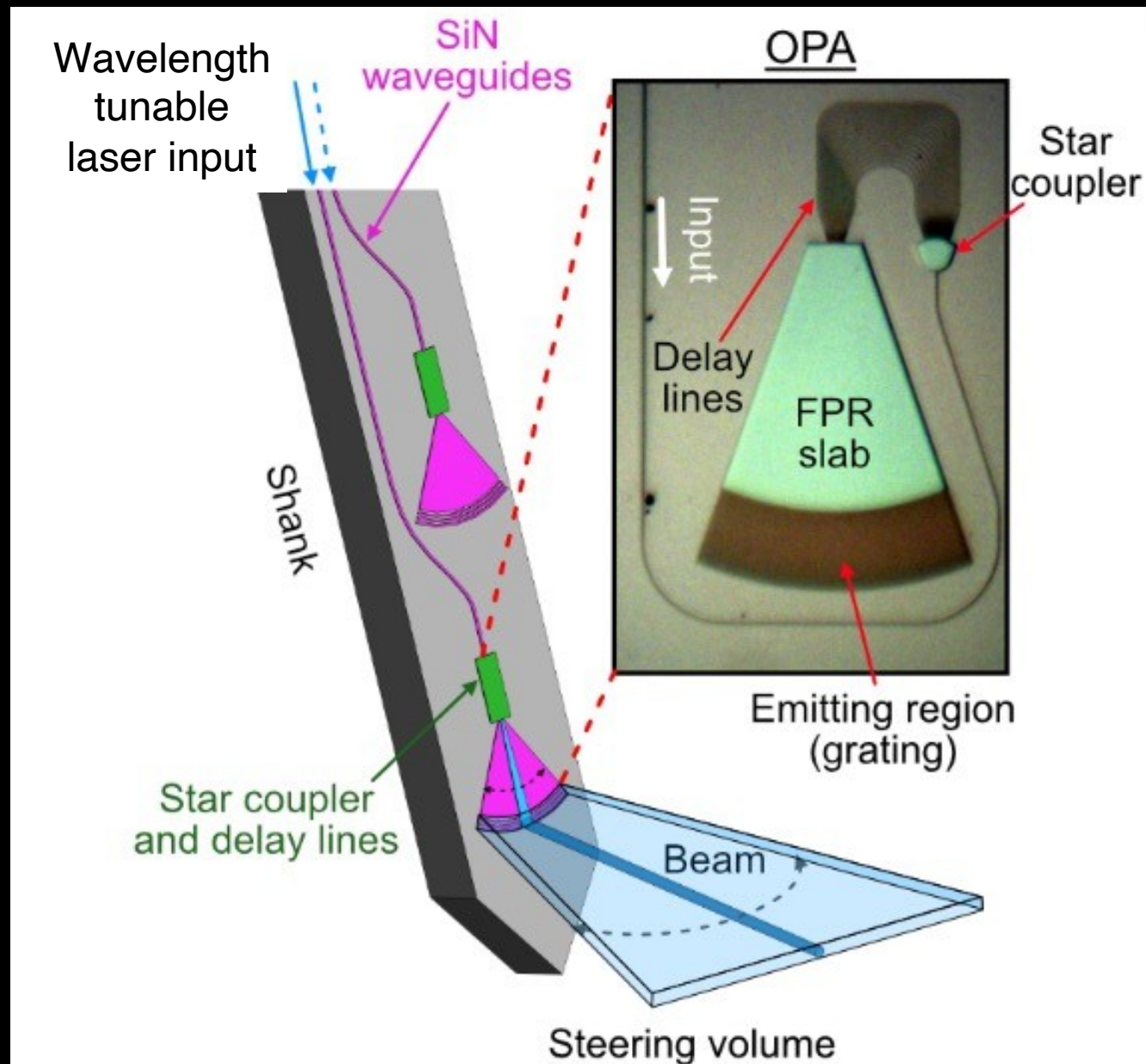
Light Evoked Activity



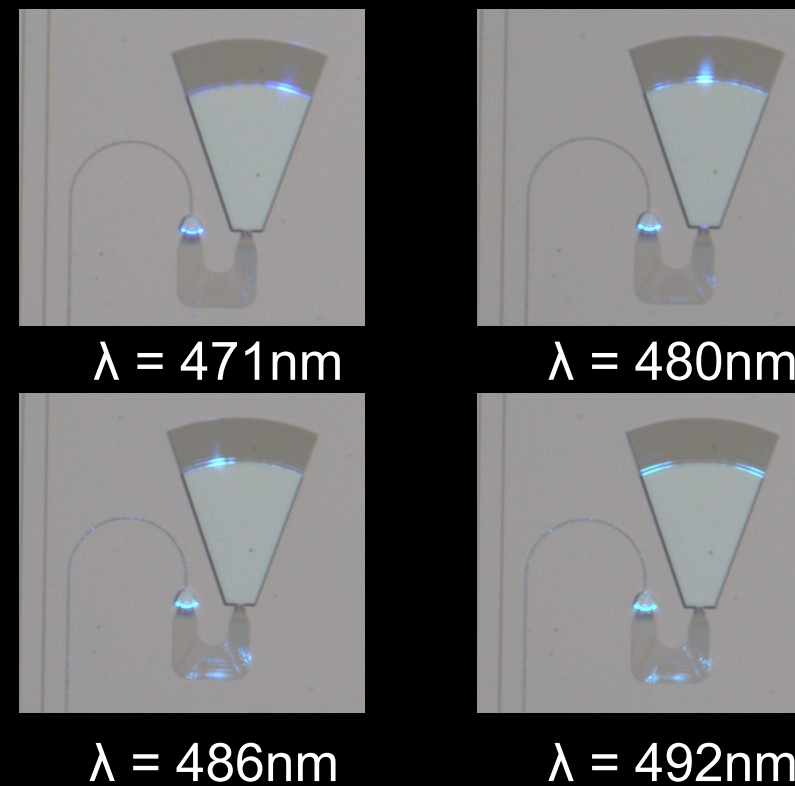
Data Analysis



Sidelobe-free beam-steering OPA

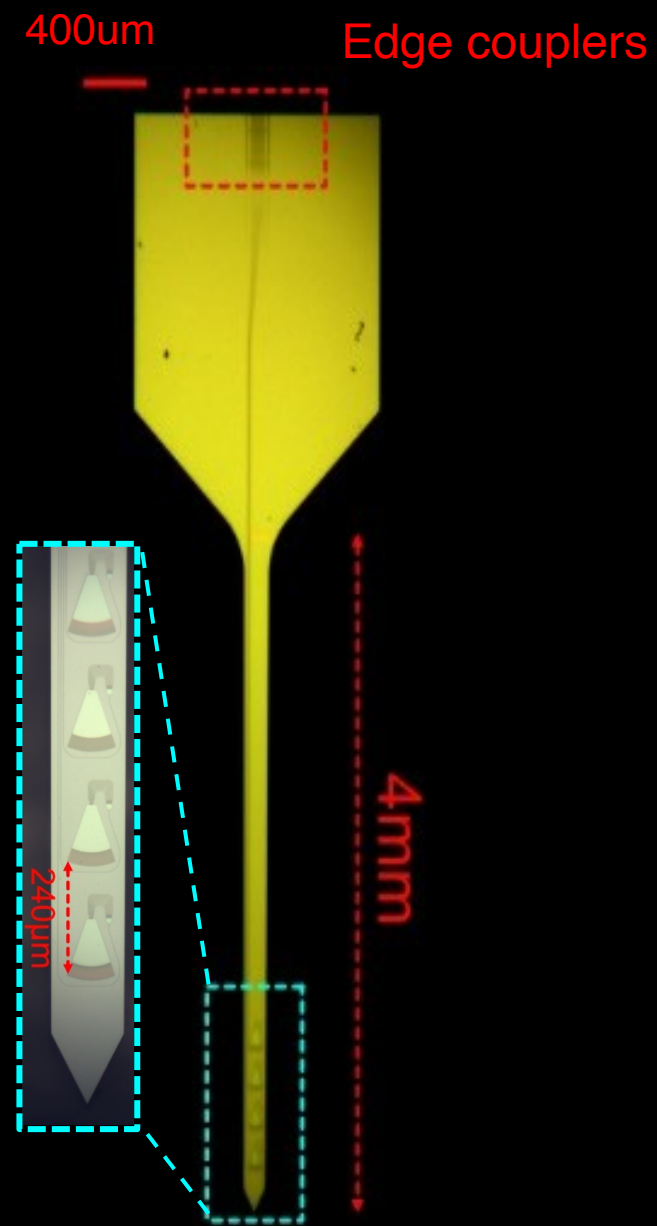


- End-fire phased array into free propagation region slab
- Sidelobes are separated from the main beam in the slab
- Out-of-plane emission by the grating



Property	Value
Free spectral range	23 nm near $\lambda=470\text{nm}$
Full steering range	23.7°
Single-lobe steering range	16°
Beam width (FWHM)	2.2°

Neuroprobe characterization



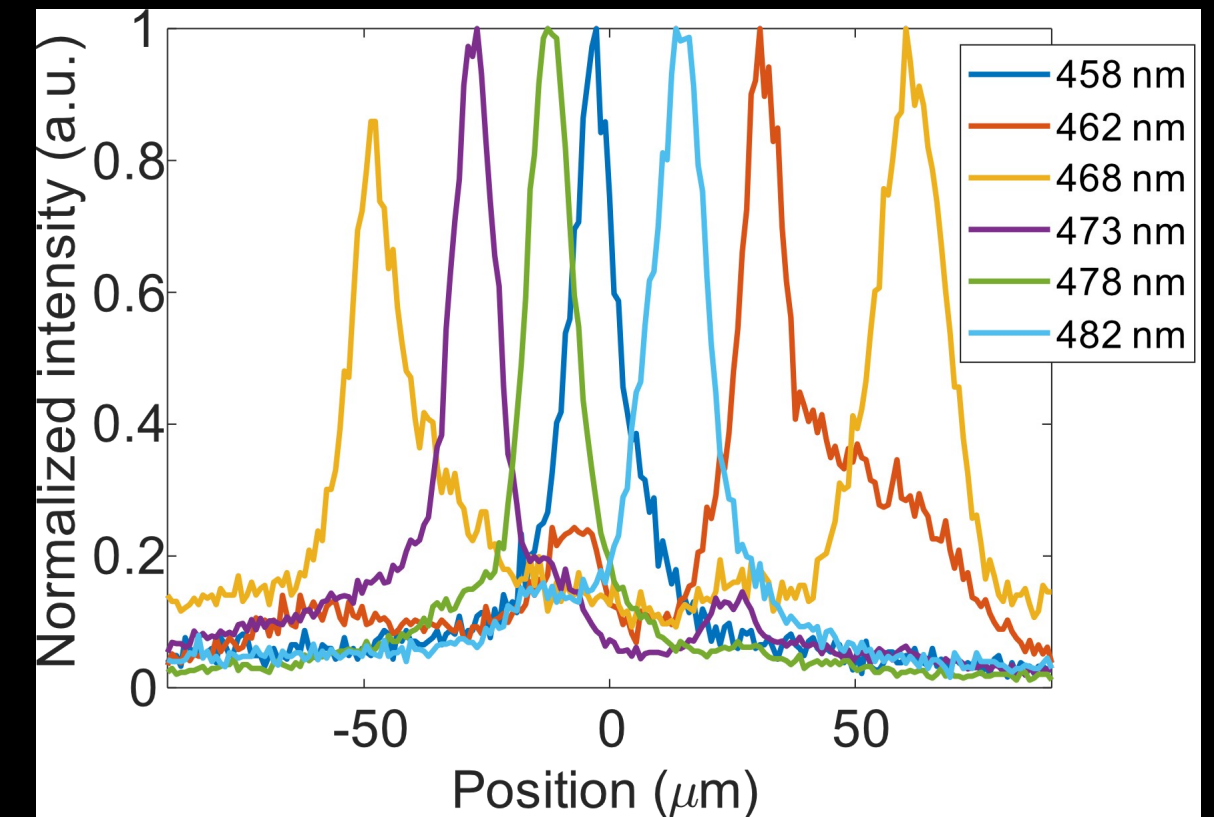
Beam profile in fluorescein

100 μm



wavelength tuning:
469 to 481 nm

Cross-section profile at 100 μm

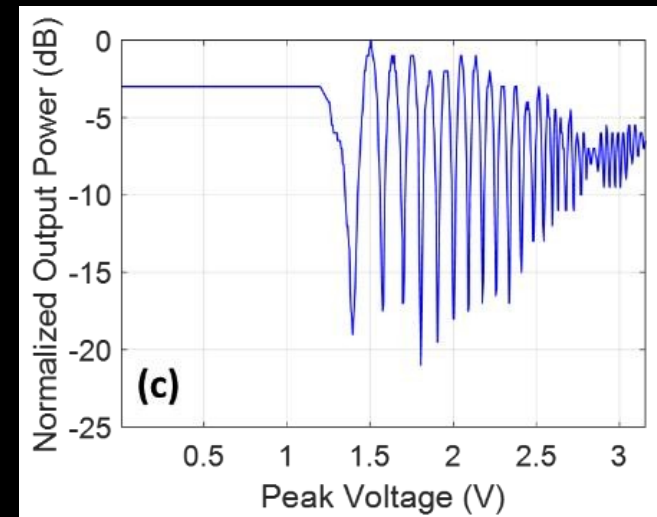
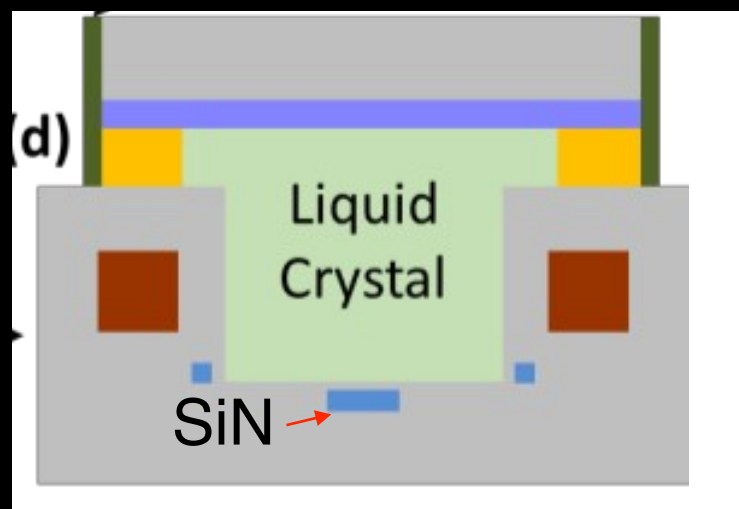


At 100 μm from the OPA, single-lobe operation:

- Steerable distance = 57 μm
- Average beam FWHM = 11.2 μm

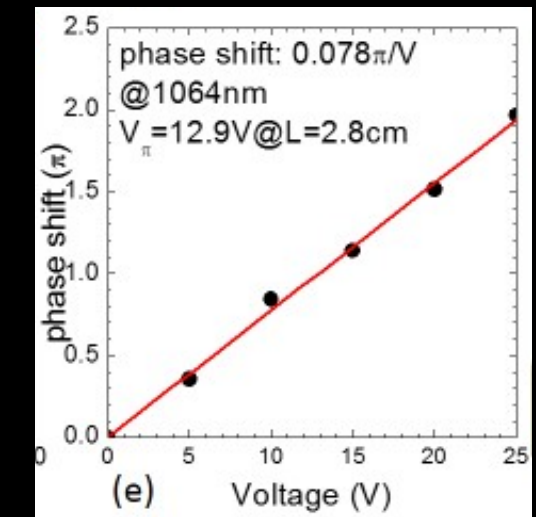
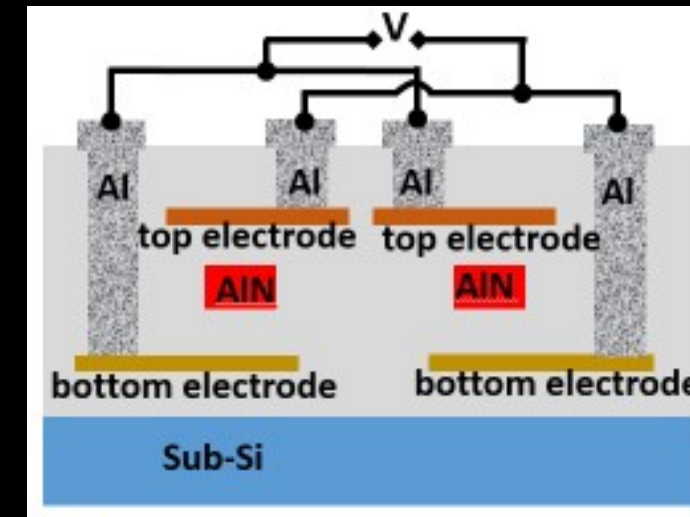
Open challenge: High-speed modulator or phase-shifter

Liquid crystal?



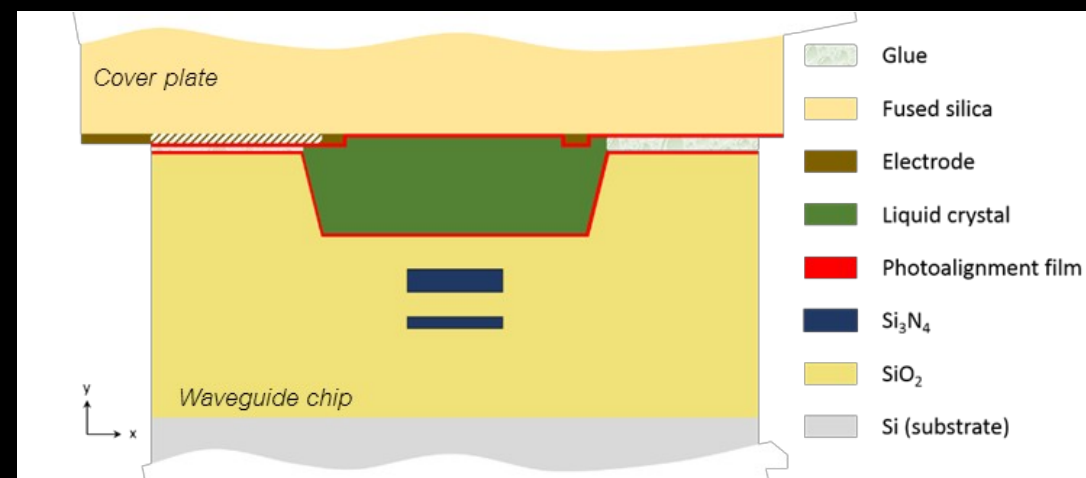
M. Notaros et al., *Frontiers in Optics*, 2018. FW6B.5

Aluminum Nitride (AlN)?

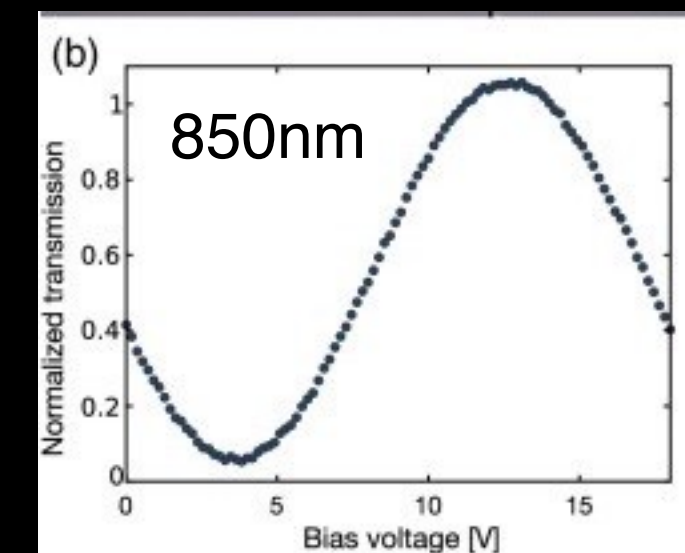
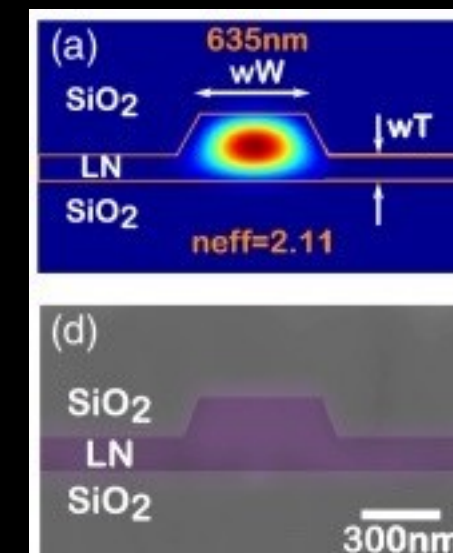


S. Zhu et al., *OFC 2019*, W2A.11.

LiNbO₃?



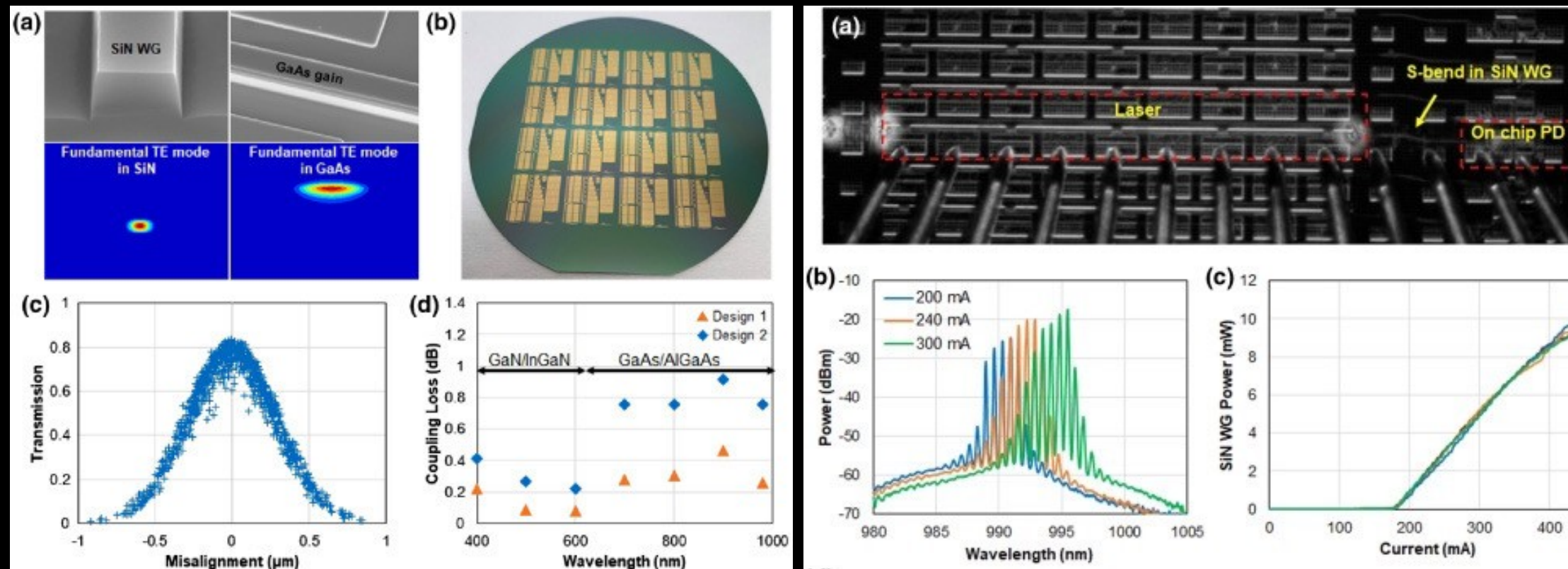
K. Wörhoff et al., *Proc. SPIE*, 2019.



B. Desiatov et al., *Optica*, 2019.

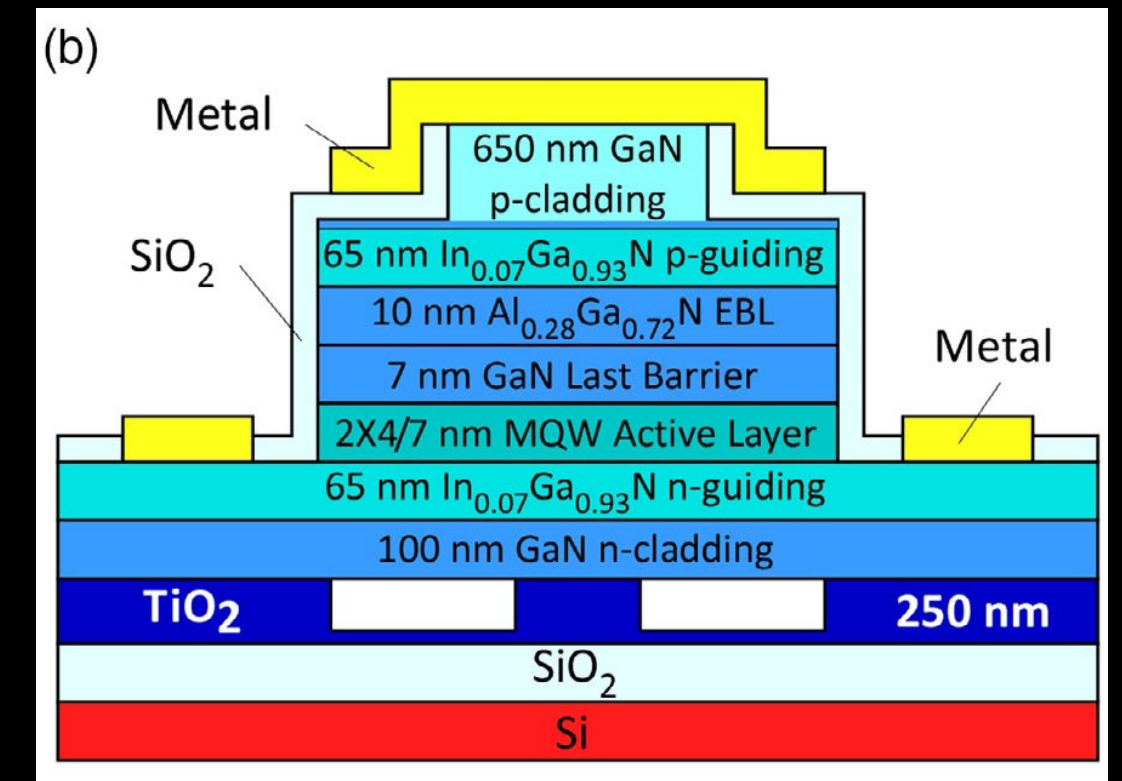
Open challenge: Laser integration

GaAs and GaN (?) integration on SiN??
(Nexus Photonics)



H. Park et al., Optica, 7: 336-337, 2020

GaN integration on TiO₂??
(UCSB, Bowers Group)

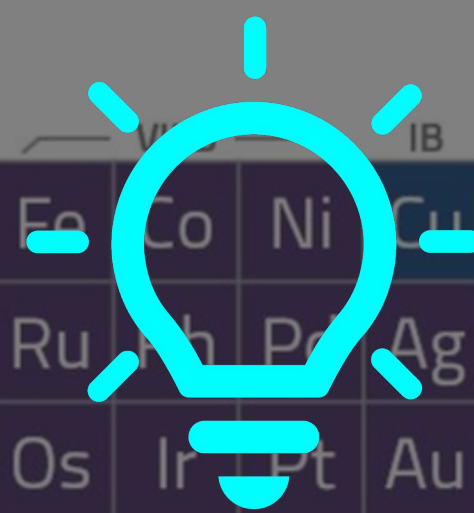


Bonding was not successful...

T. Kamei et al., Physica Status
Solidi A, 1900770, 2020

Many elements used in the semiconductor industry!

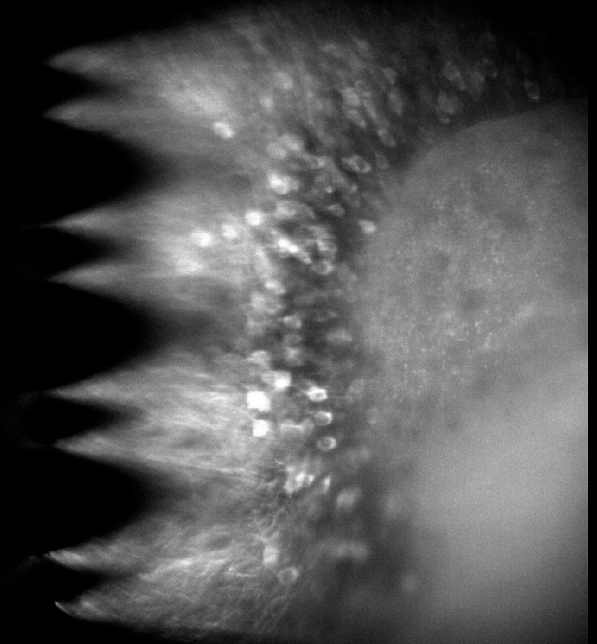
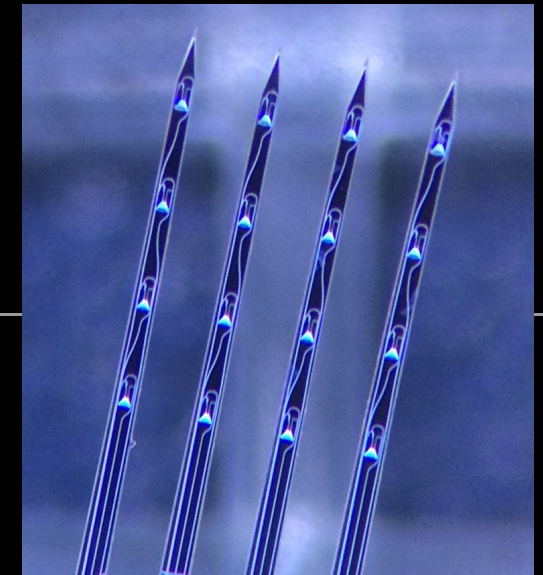
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		■ <i>Used in/before 1980s</i>					■ <i>Added or explored in 2000s</i>																																				
		■ <i>Added in 1990s</i>					■ <i>Added or explored in 2010s</i>																																				
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H												He																															
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Fr	Ra	Ac	Rf	Db	Sg	Bh	Hs	Mt	Ds	Rg	Cn	Nh	Fl	Mc	Lv	Ts	Og																										
		<table border="1"> <tr> <td>Ce</td><td>Pr</td><td>Nd</td><td>Pm</td><td>Sm</td><td>Eu</td><td>Gd</td><td>Tb</td><td>Dy</td><td>Ho</td><td>Er</td><td>Tm</td><td>Yb</td><td>Lu</td> </tr> <tr> <td>Th</td><td>Pa</td><td>U</td><td>Np</td><td>Pu</td><td>Am</td><td>Cm</td><td>Bk</td><td>Cf</td><td>Es</td><td>Fm</td><td>Md</td><td>No</td><td>Lr</td> </tr> </table>														Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr
Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu																														
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Summary:

Visible light photonics and neurophotonics

- Foundry Si photonics for visible light ⇒ **A new class of nano-neurophonic tools for brain recording & stimulation**
- Passive neurophonic probes bring patterned photostimulation into brain tissues without any lenses
- Applications of visible light photonics: biosensing, quantum photonics, optical phased arrays
- Opportunities for new devices, platforms, and integration approaches



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www.photon.utoronto.ca | www.mpi-halle.mpg.de/NINT

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